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Shen

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(54) **INTEGRATED CIRCUIT CHIP AND METHOD FOR FABRICATING THE SAME**

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(22) Filed: **Feb. 22, 2001**

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Foreign Application Priority Data

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(51) **Int. Cl.**⁷ **H01L 23/48**

(52) **U.S. Cl.** **257/723; 257/734; 257/690; 257/784**

(58) **Field of Search** **257/734, 680, 257/687, 690, 784, 787**

(56) **References Cited**

U.S. PATENT DOCUMENTS

- 4,649,418 A * 3/1987 Uden 357/80
- 4,931,853 A * 6/1990 Ohuchi et al. 357/74
- 5,107,328 A * 4/1992 Kinsman
- 5,243,497 A * 9/1993 Chiu 361/783
- 5,384,689 A * 1/1995 Shen 361/761
- 5,502,289 A * 3/1996 Takiar et al. 174/266

- 5,677,566 A * 10/1997 King et al. 257/666
- 5,723,907 A * 3/1998 Akram 257/723
- 5,739,585 A * 4/1998 Akram et al. 257/698
- 5,777,381 A * 7/1998 Nishida 257/693
- 5,811,879 A * 9/1998 Akram 257/723
- 5,818,698 A * 10/1998 Corisis 261/760
- 5,952,611 A * 9/1999 Eng et al. 174/52.4
- 5,998,860 A * 12/1999 Chan et al. 257/679
- 5,998,865 A * 12/1999 Akram 257/723
- 6,107,683 A * 8/2000 Castro et al. 257/700

* cited by examiner

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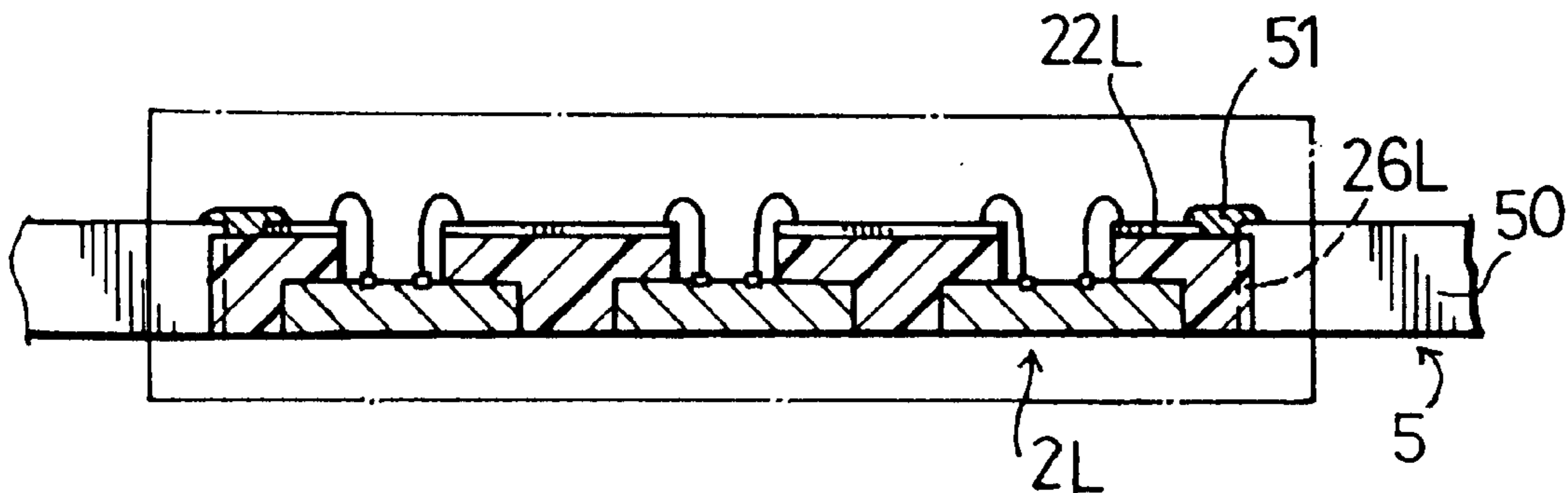
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(57) **ABSTRACT**

A method for fabricating an integrated circuit chip includes the steps of:

- (a) forming a circuit board unit with a die-receiving cavity, and a plurality of contact pads on a top surface of the circuit board unit;
- (b) forming a die having an upper surface provided with a plurality of solder pads;
- (c) placing the die in the die-receiving cavity such that the solder pads on the die are exposed;
- (d) wire-bonding the solder pads to the contact pads via conductive wires;
- (e) placing a lead frame on the circuit board unit, and connecting leads on the lead frame to corresponding ones of the contact pads via a conductive contact layer; and
- (f) forming a plastic protective layer to encapsulate the circuit board unit and at least a portion of the lead frame.

9 Claims, 12 Drawing Sheets



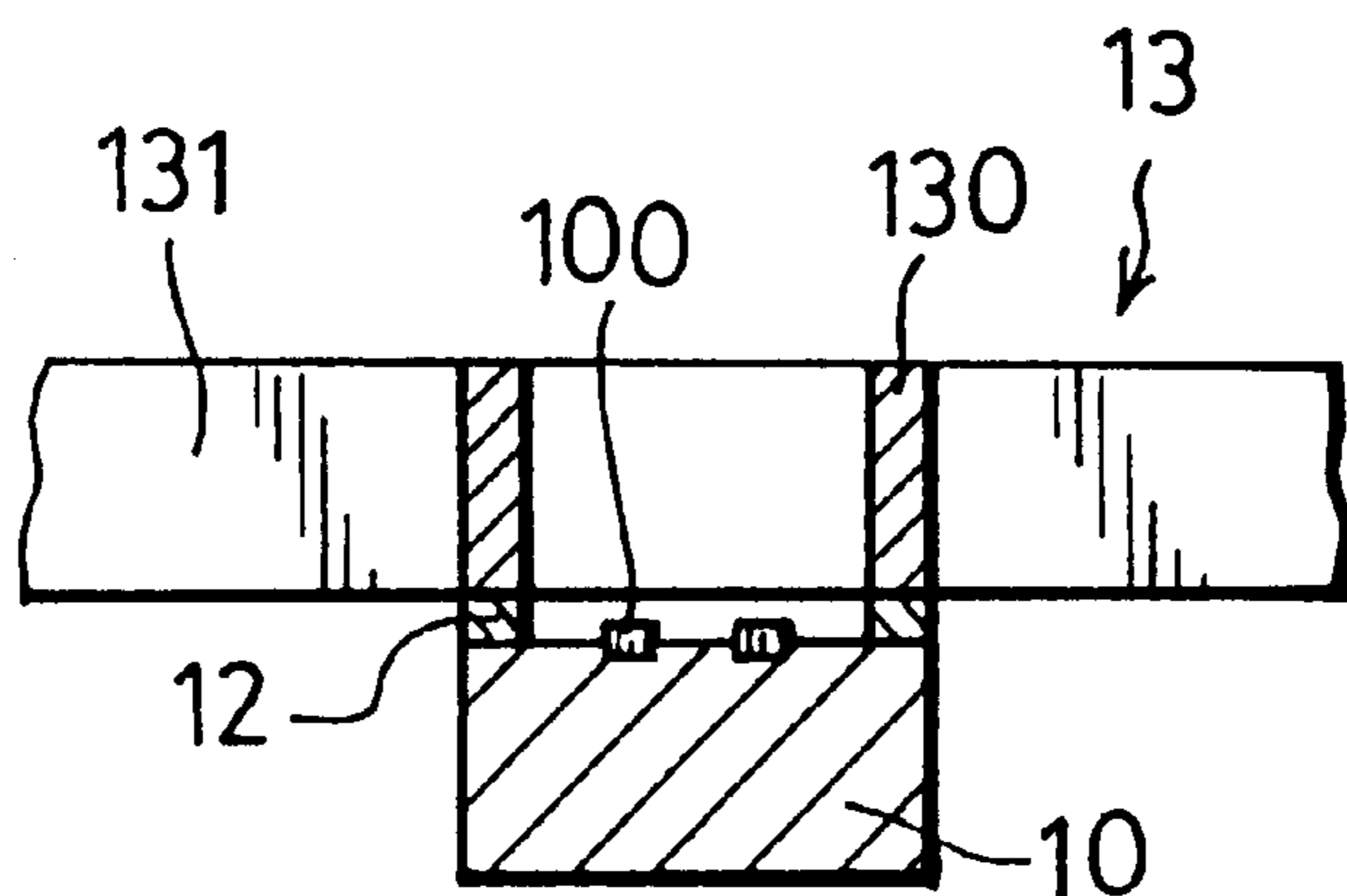


FIG. 1A
PRIOR ART

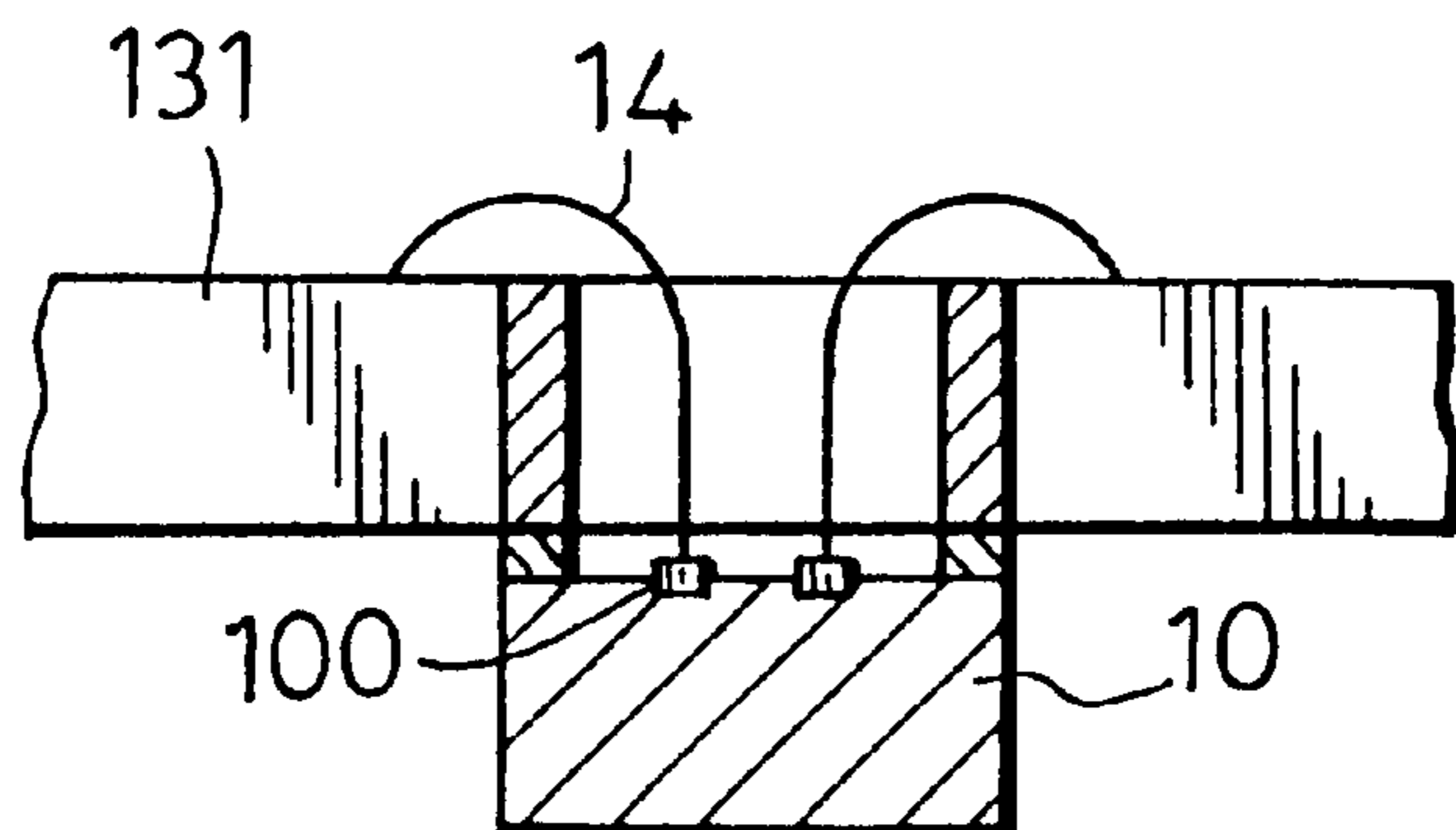


FIG. 1B
PRIOR ART

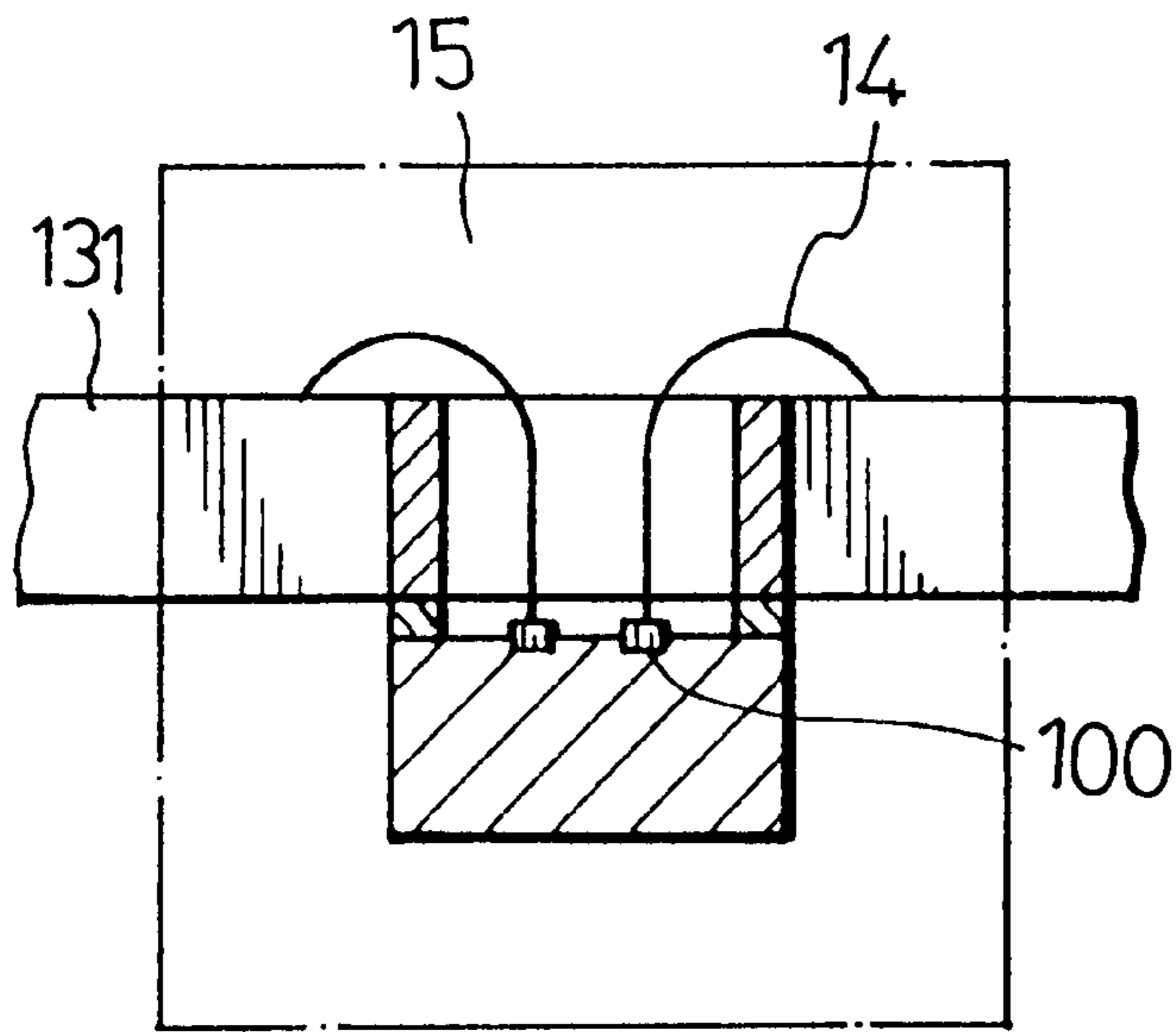


FIG. 1C
PRIOR ART

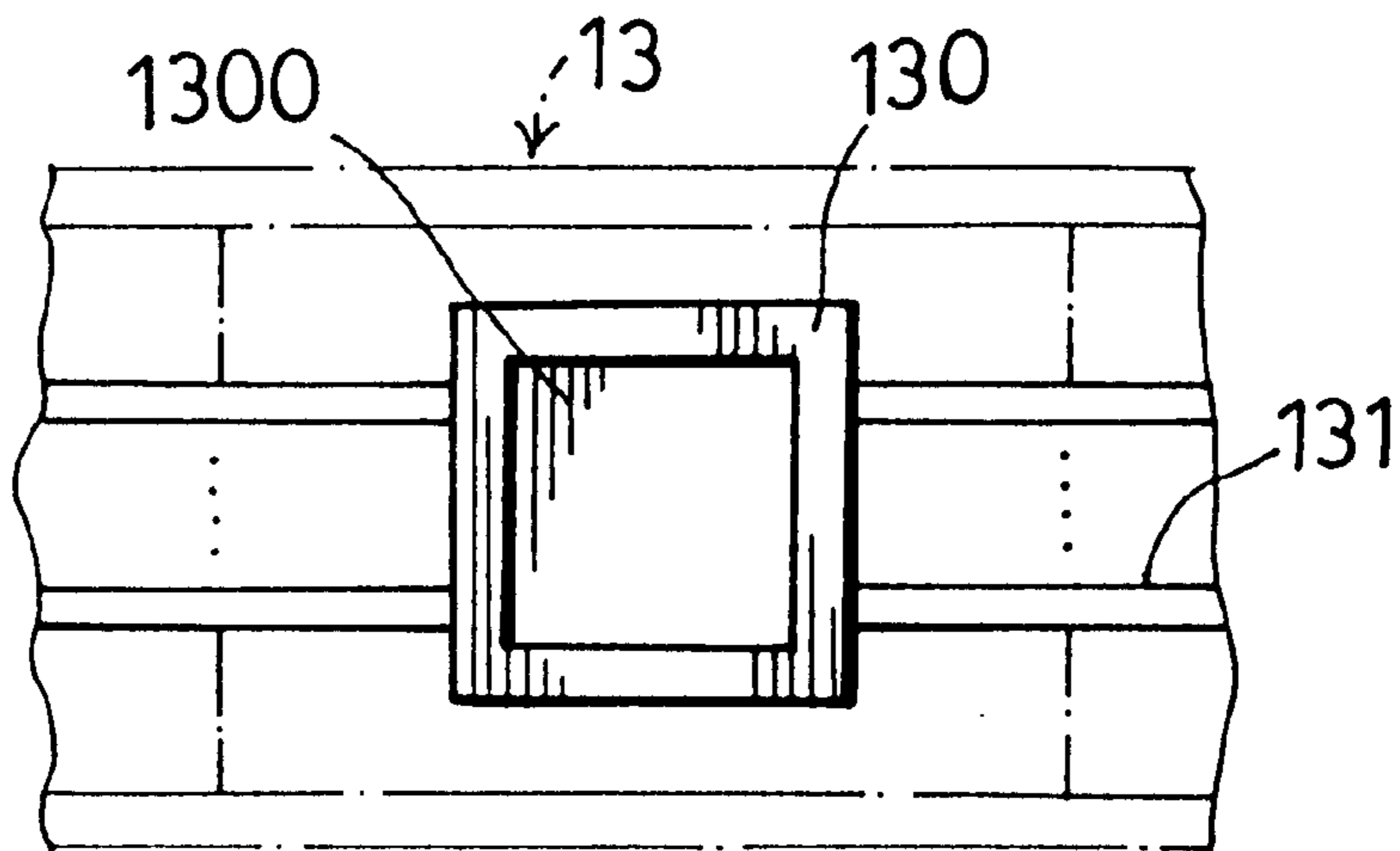


FIG. 1D
PRIOR ART

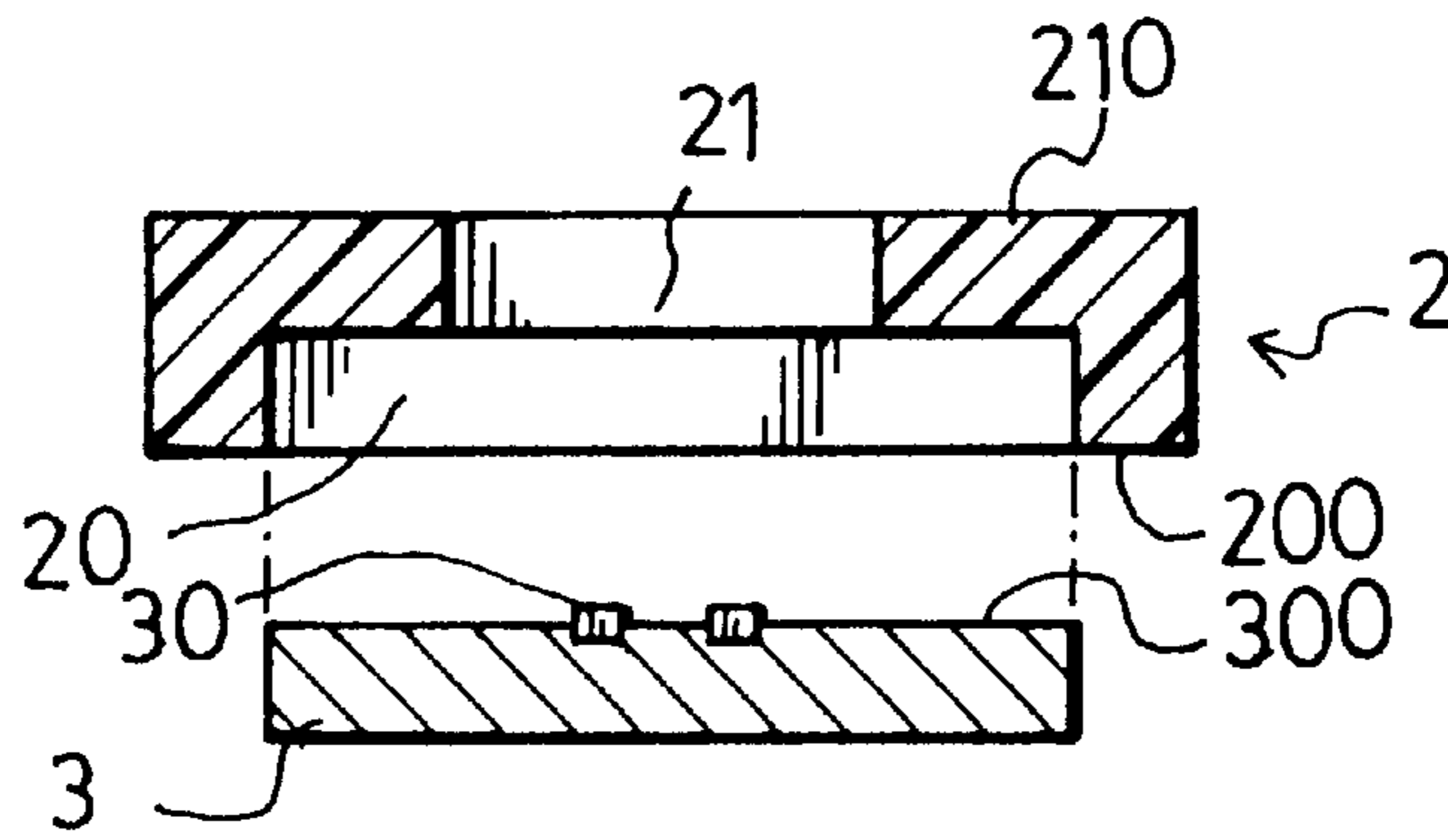


FIG. 2A

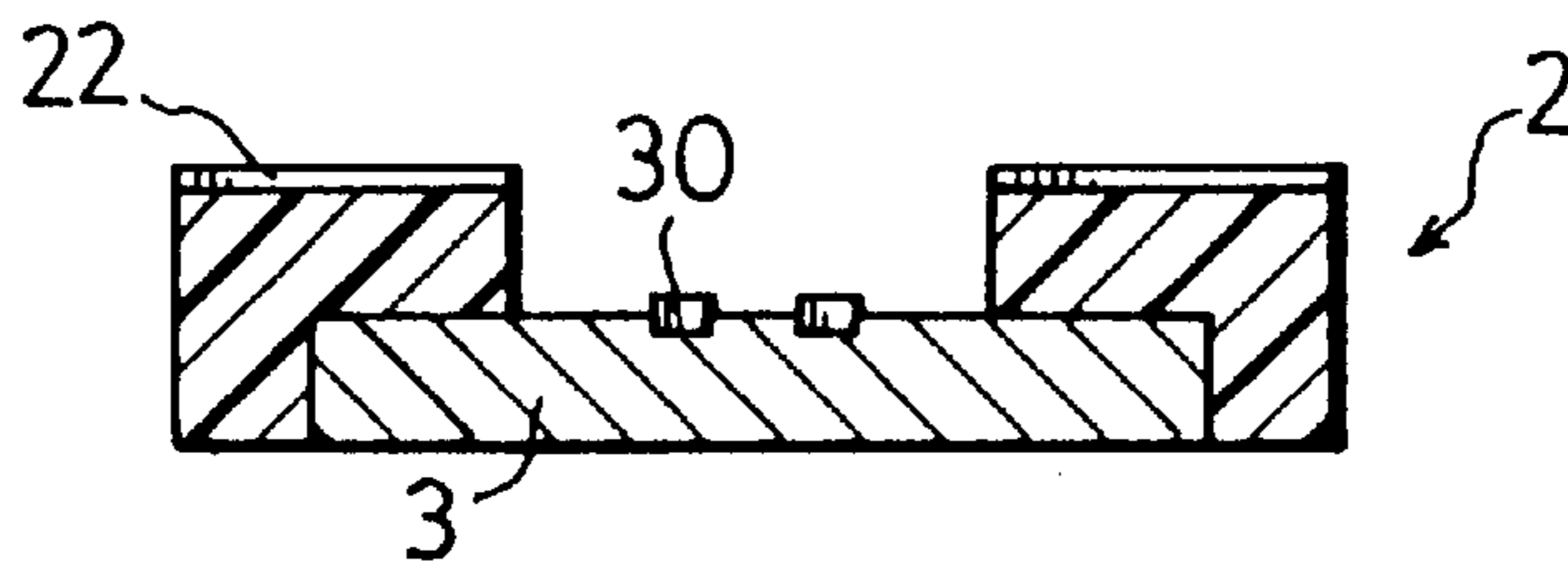


FIG. 2B

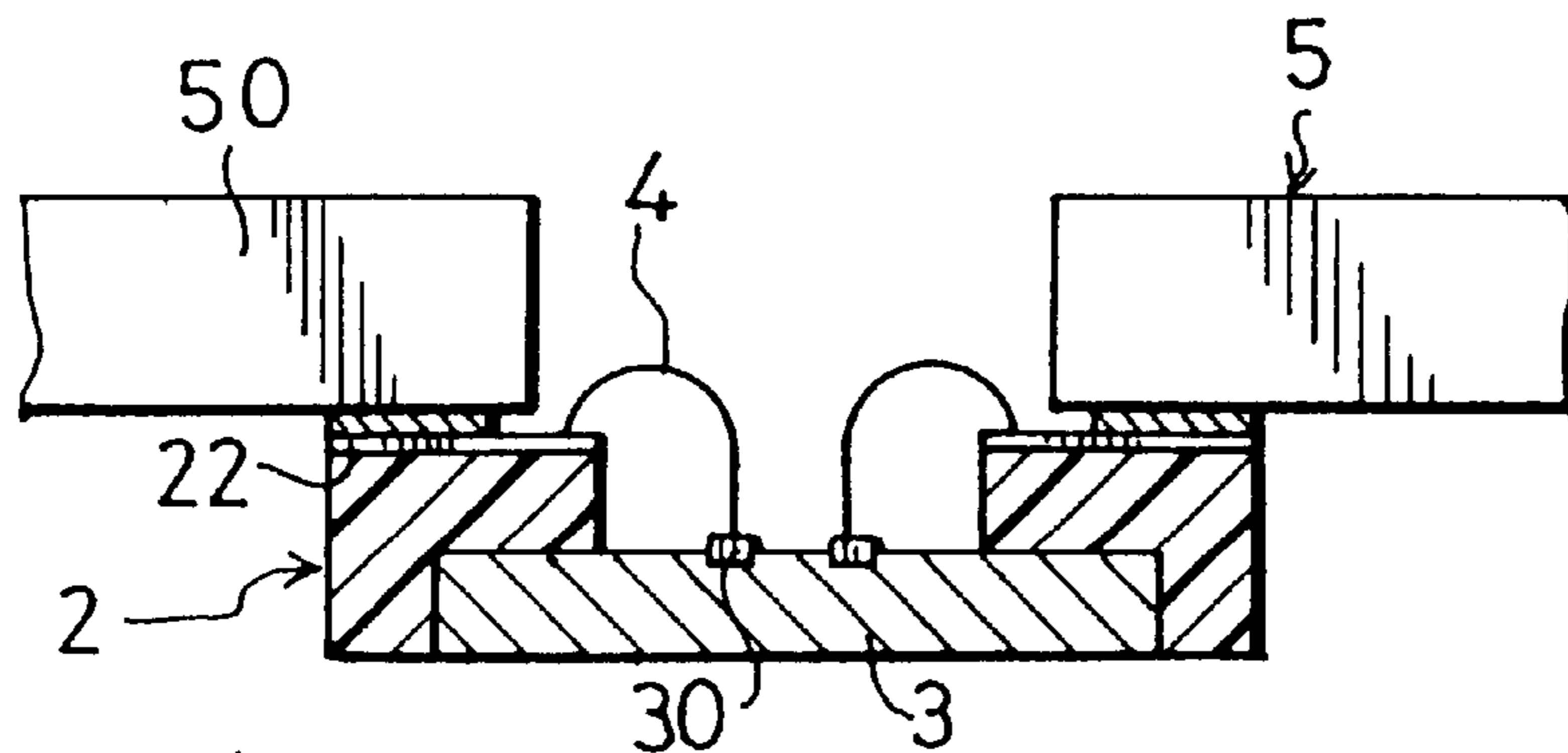


FIG. 2C

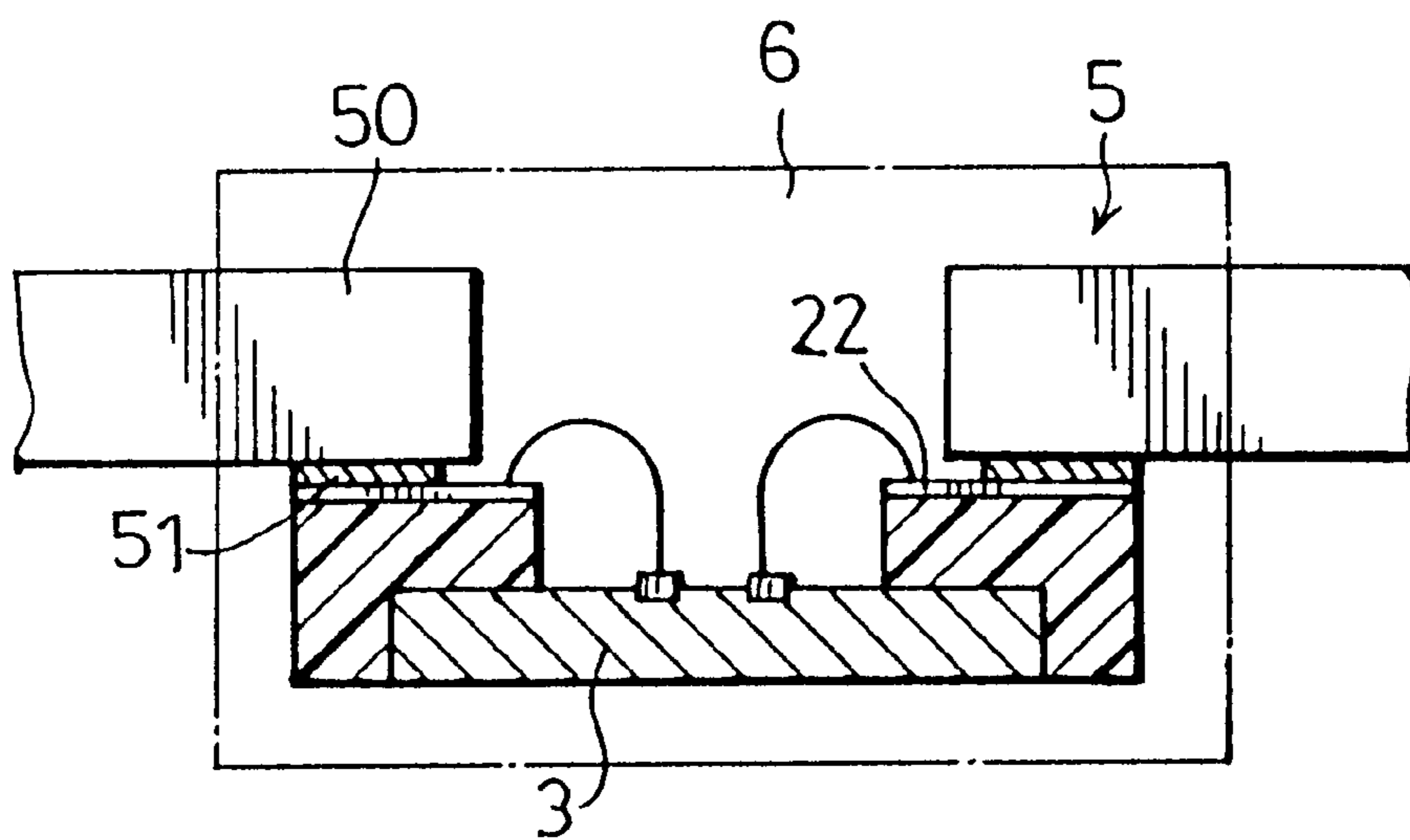


FIG. 2D

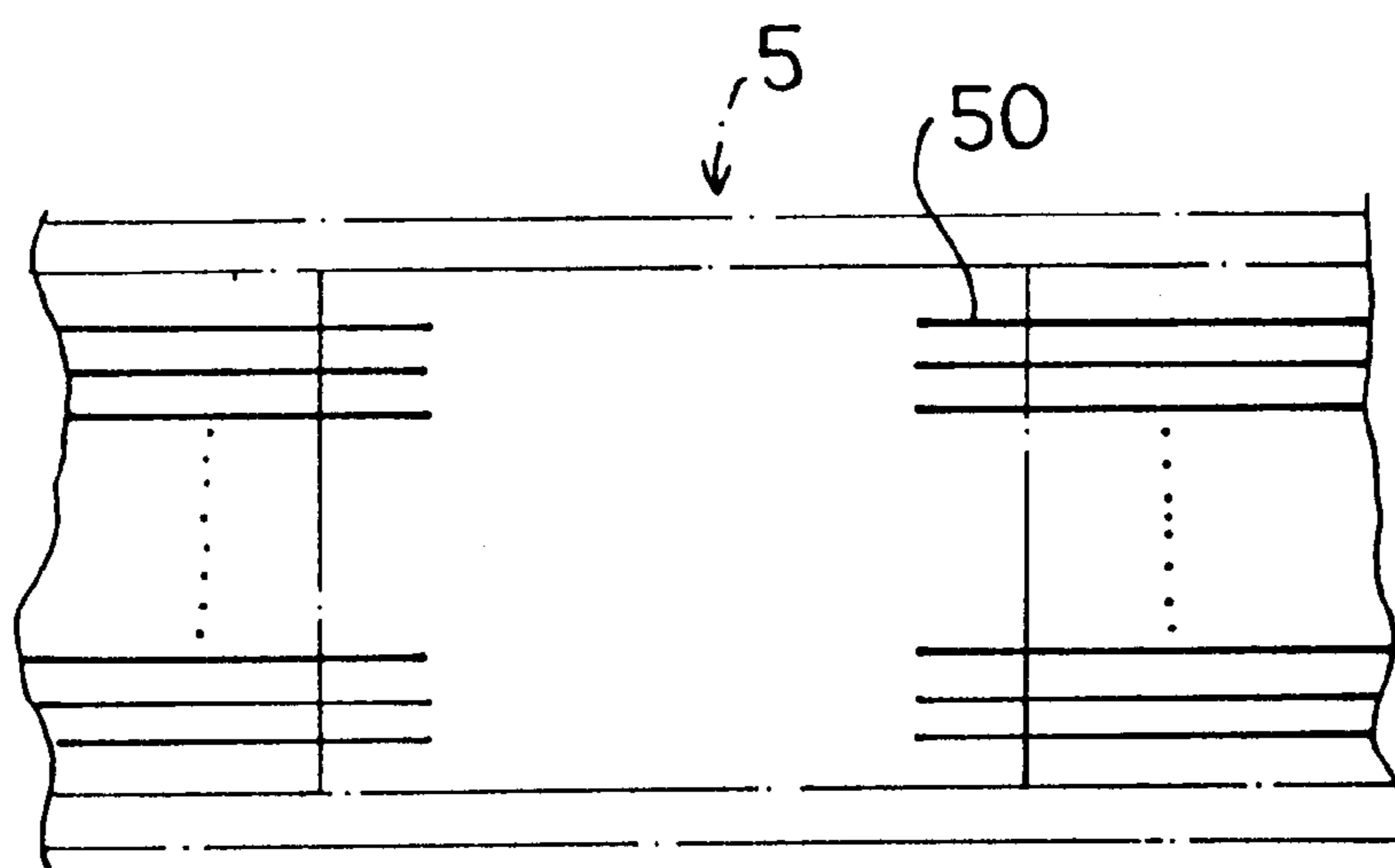


FIG. 2E

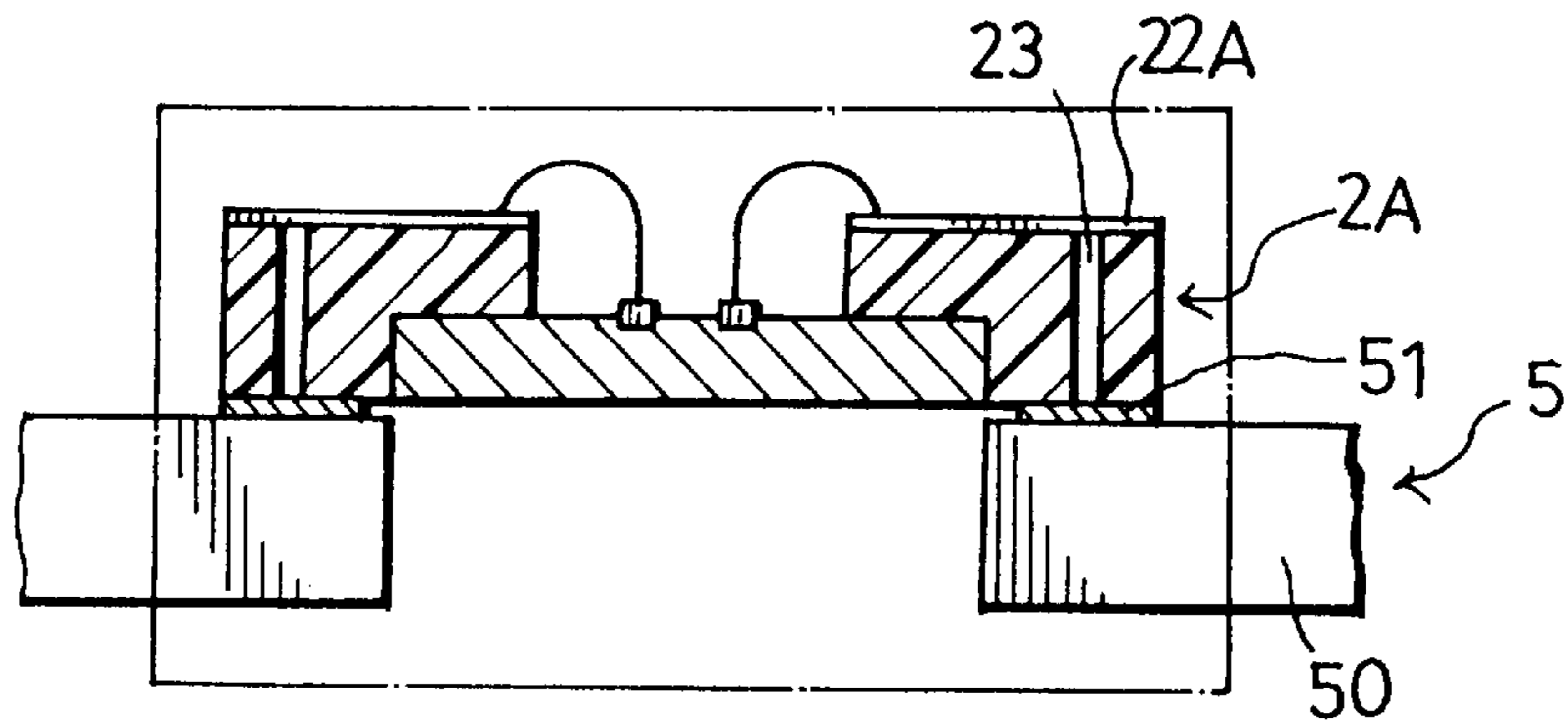


FIG. 3

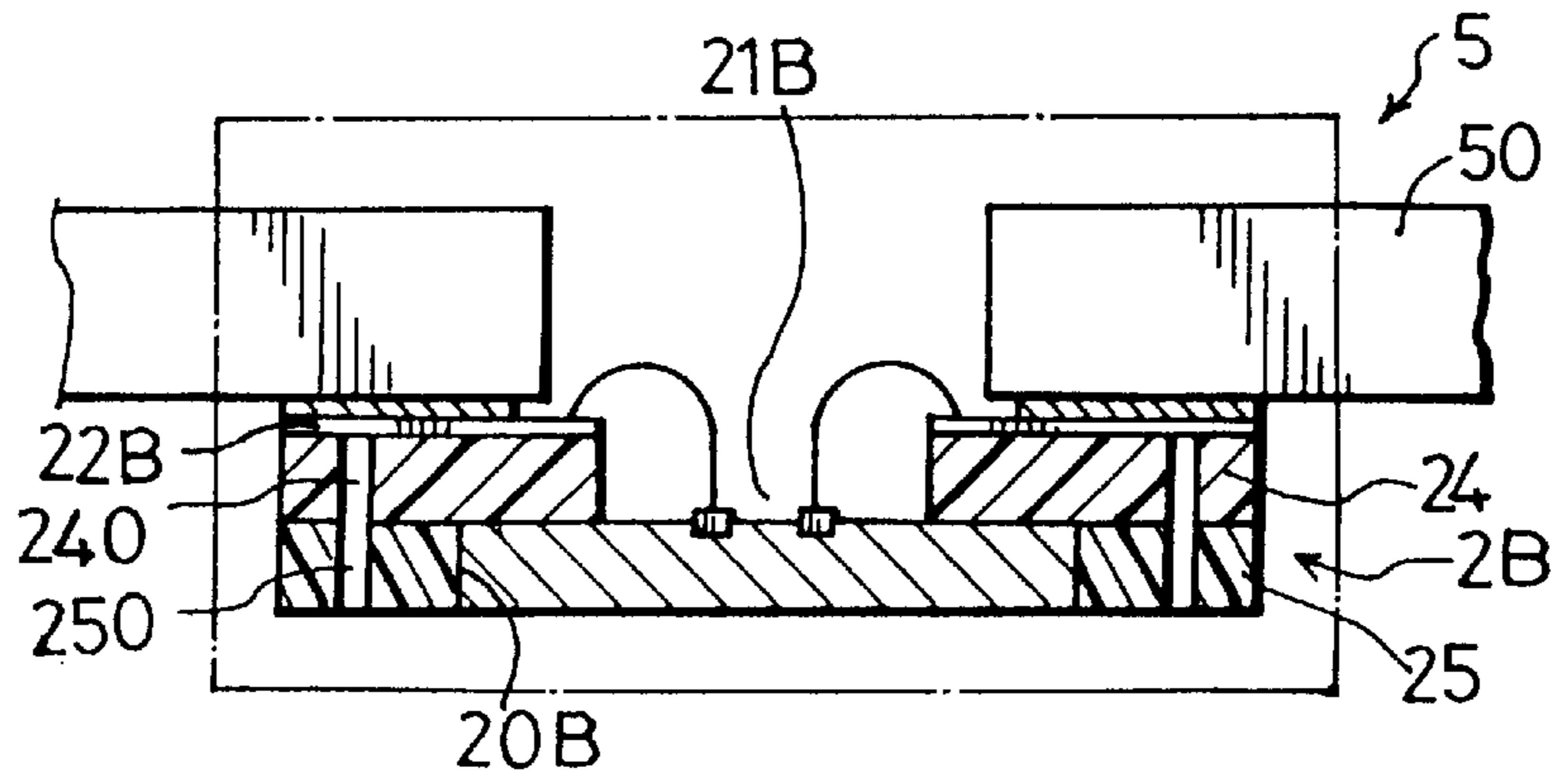


FIG. 4

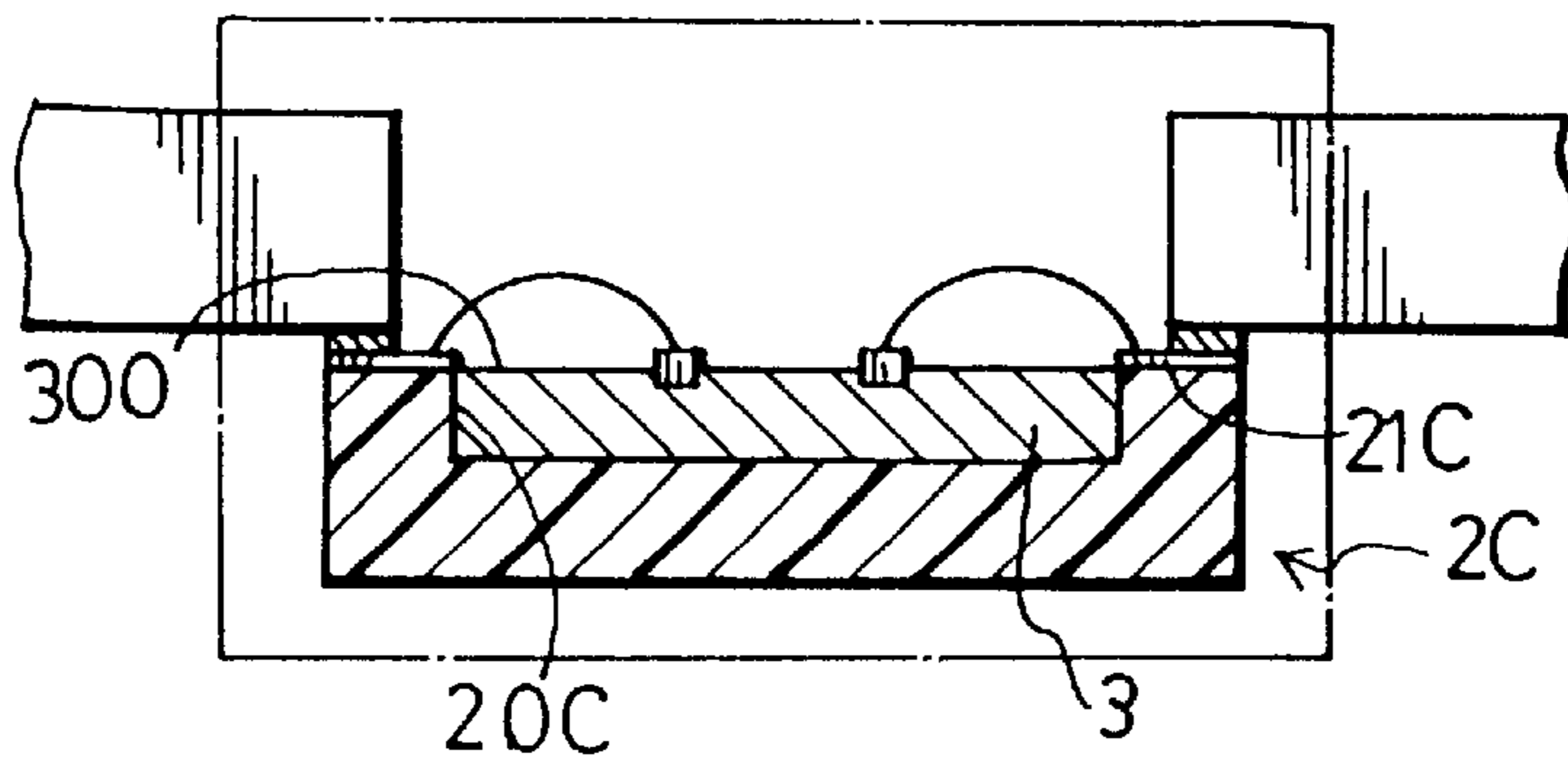


FIG. 5

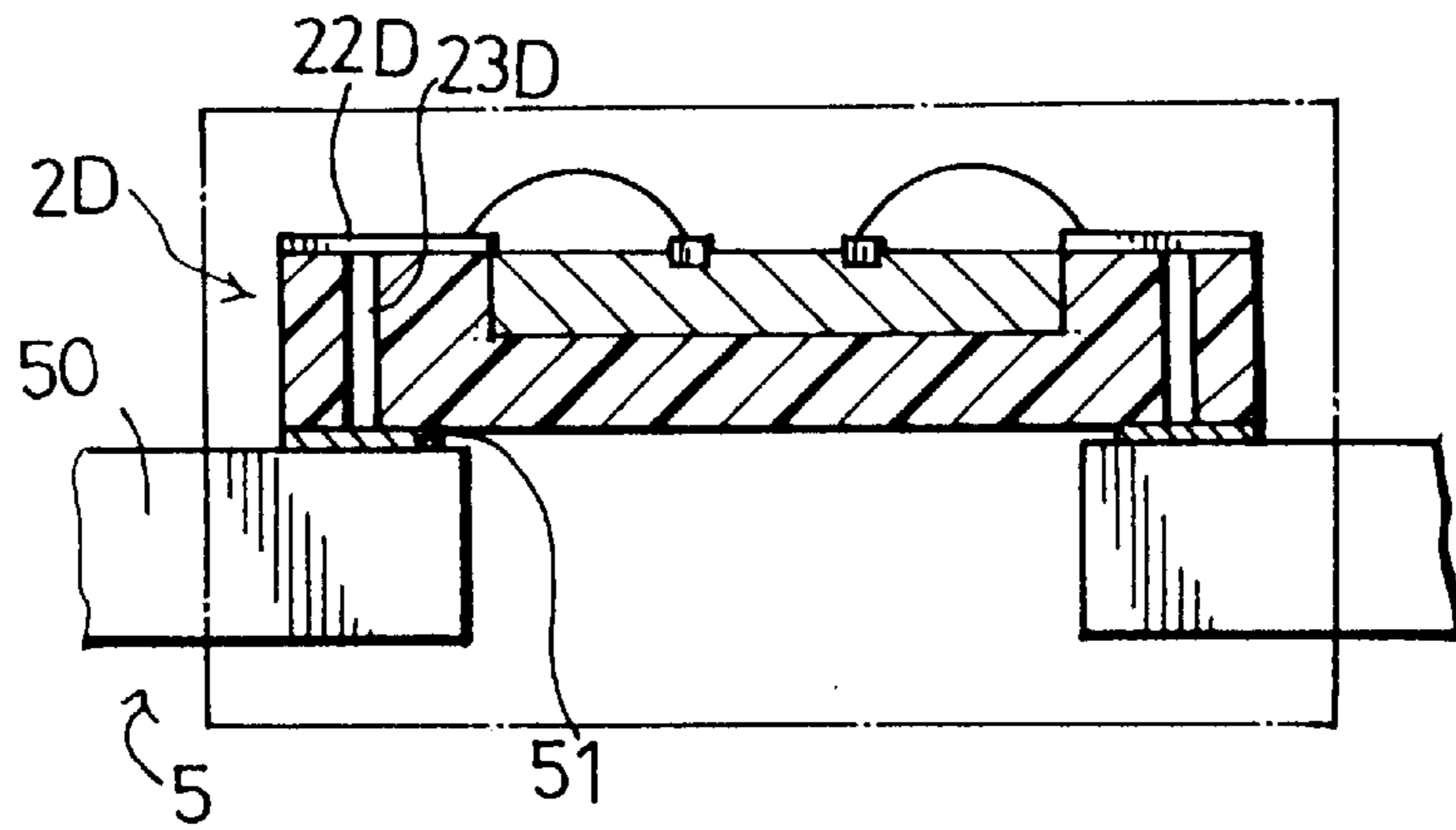


FIG. 6

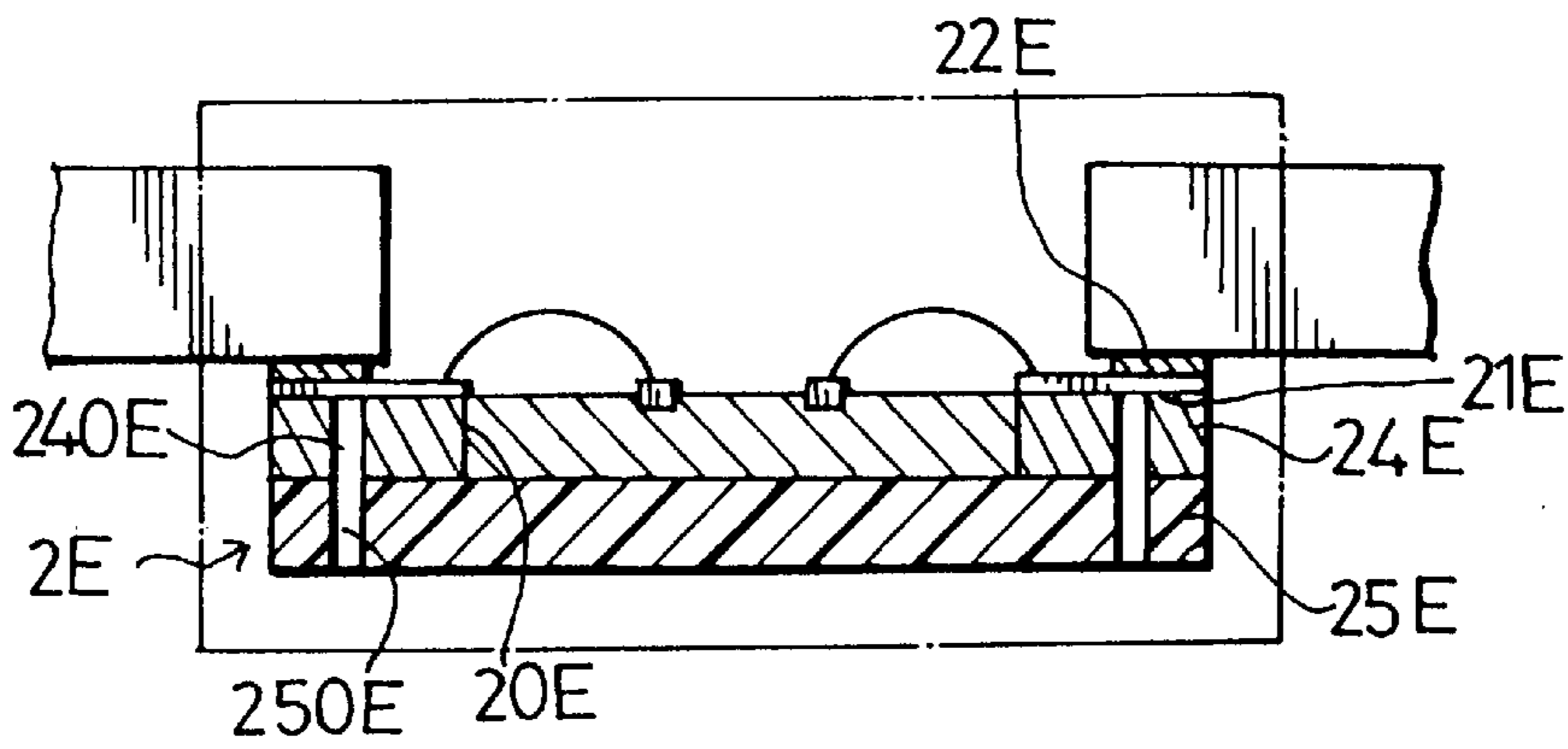


FIG. 7

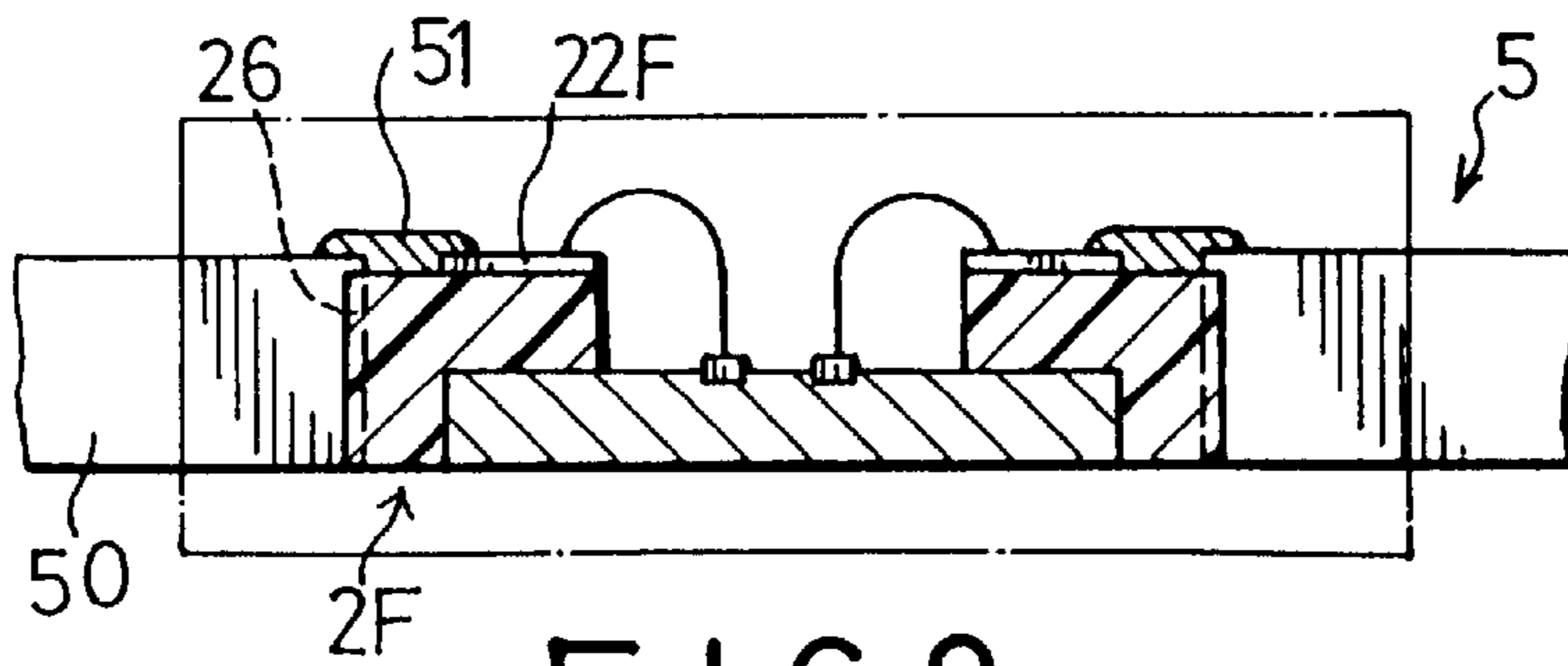


FIG. 8

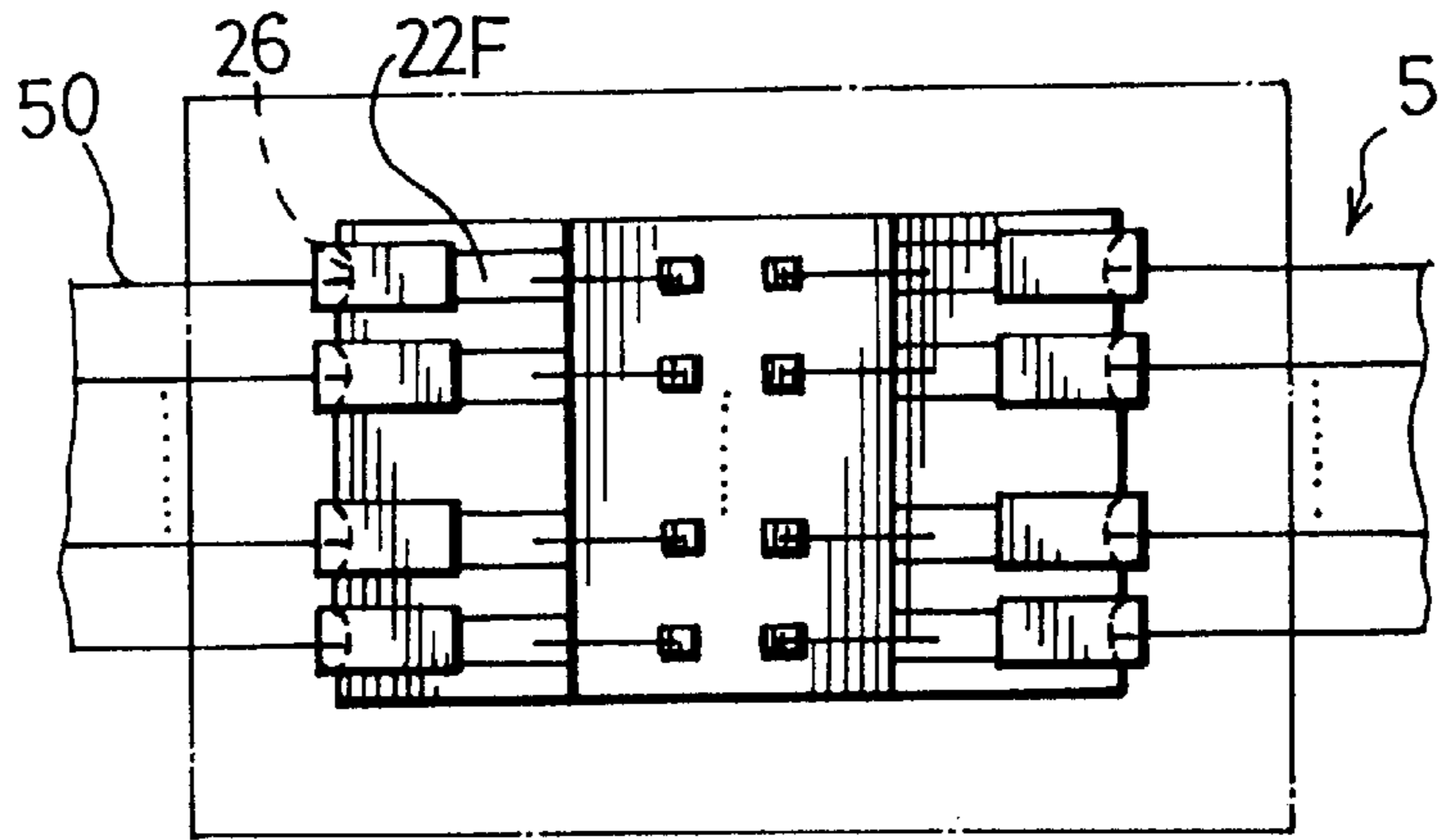


FIG. 9

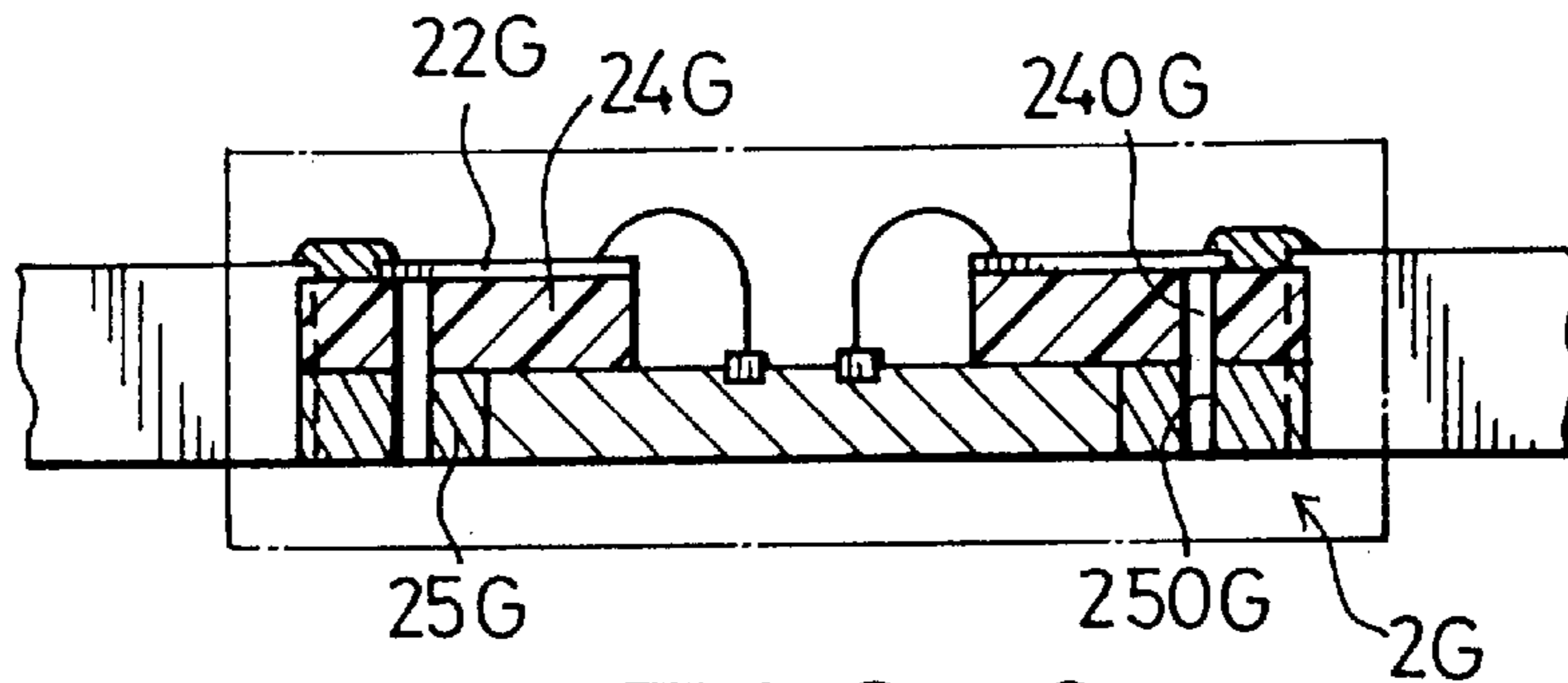


FIG. 10

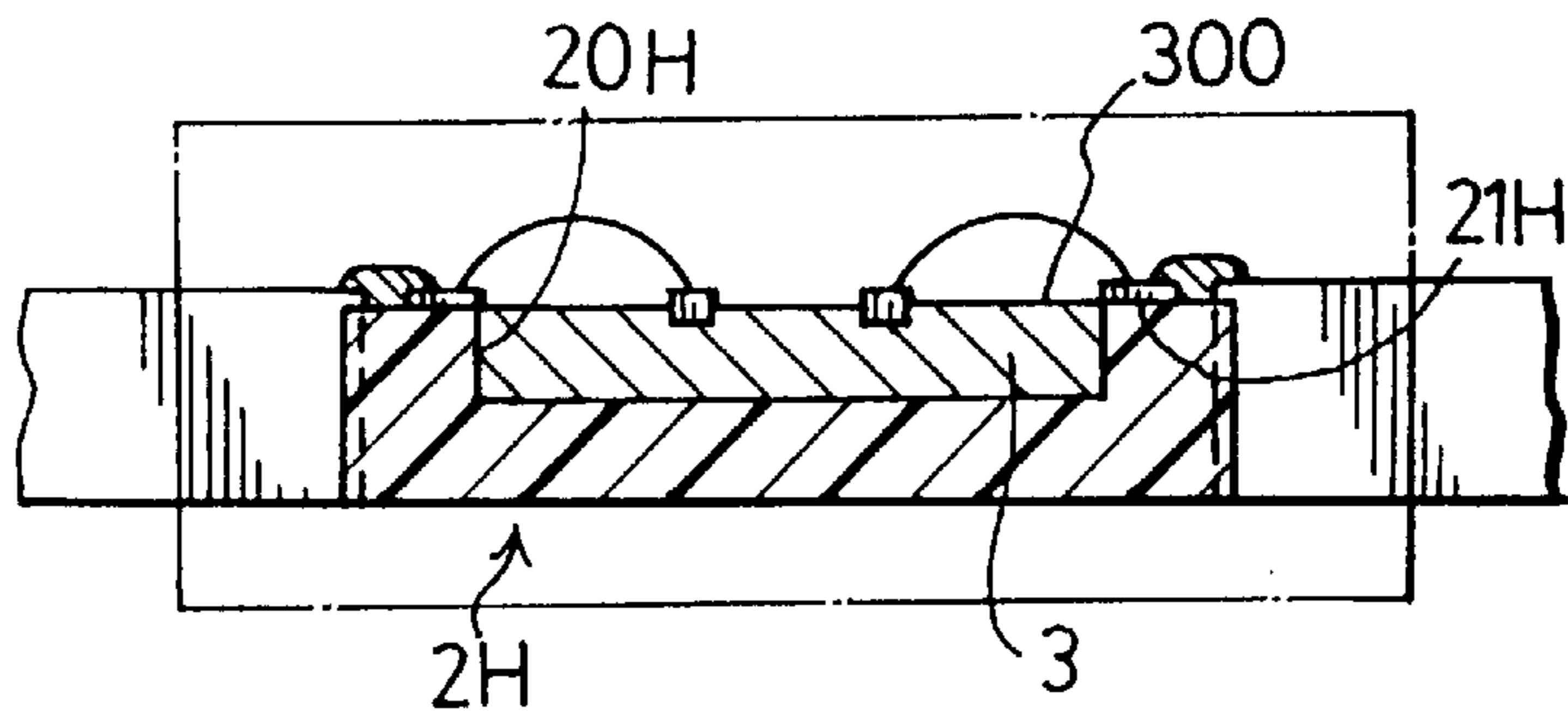


FIG. 11

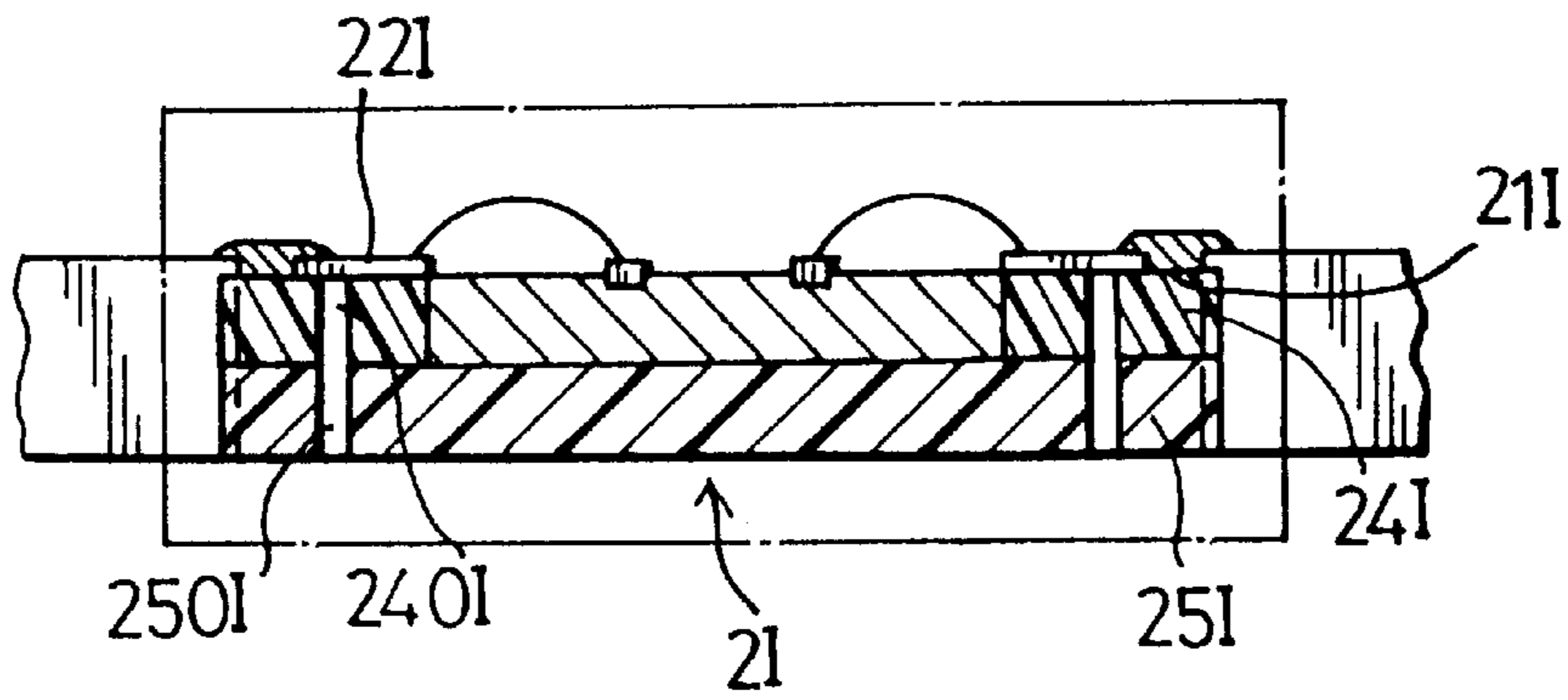


FIG. 12

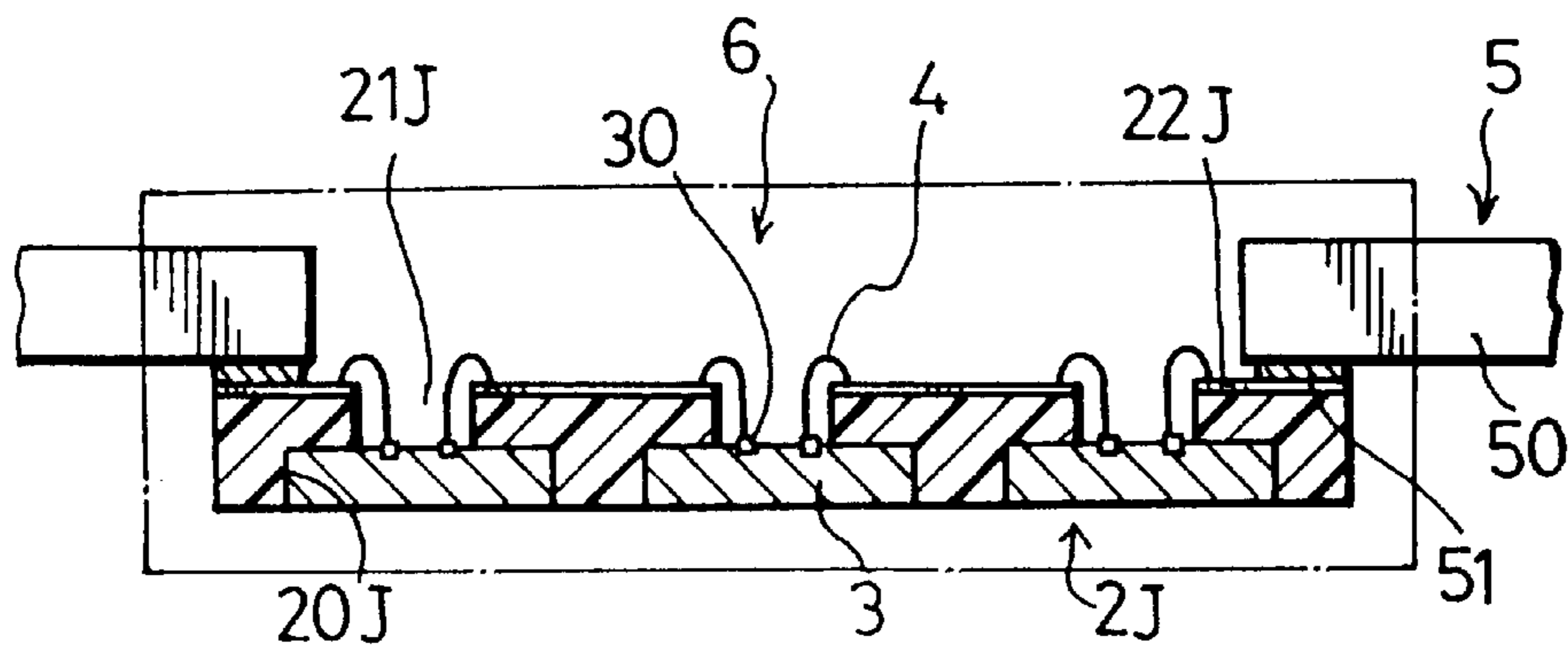


FIG. 13

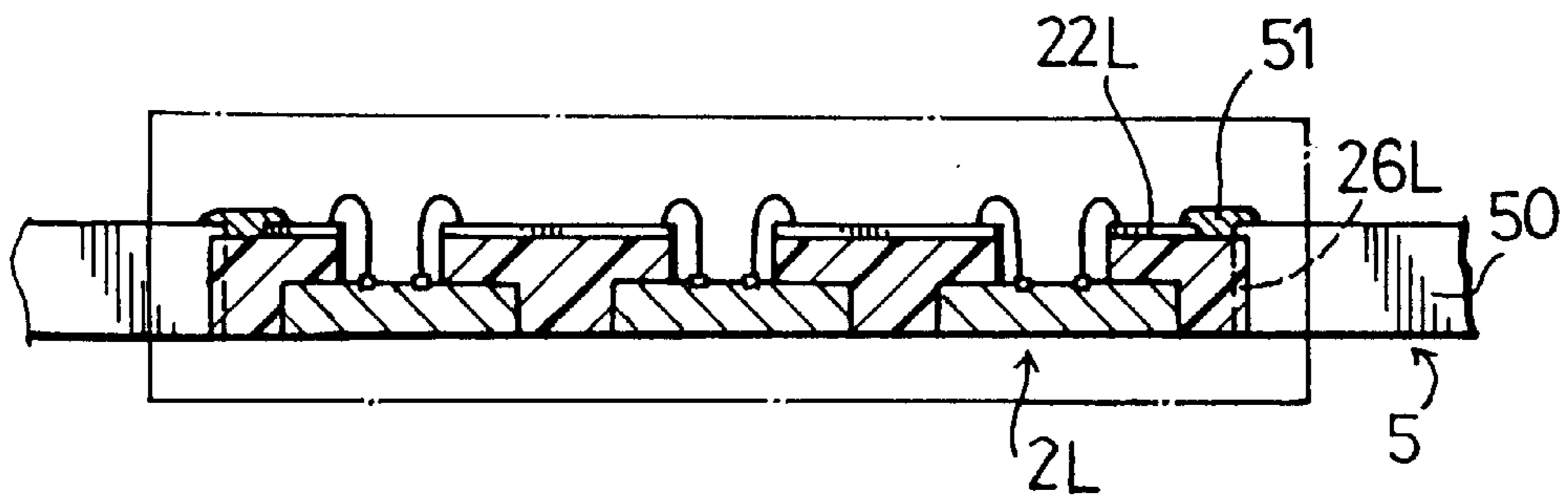


FIG. 14

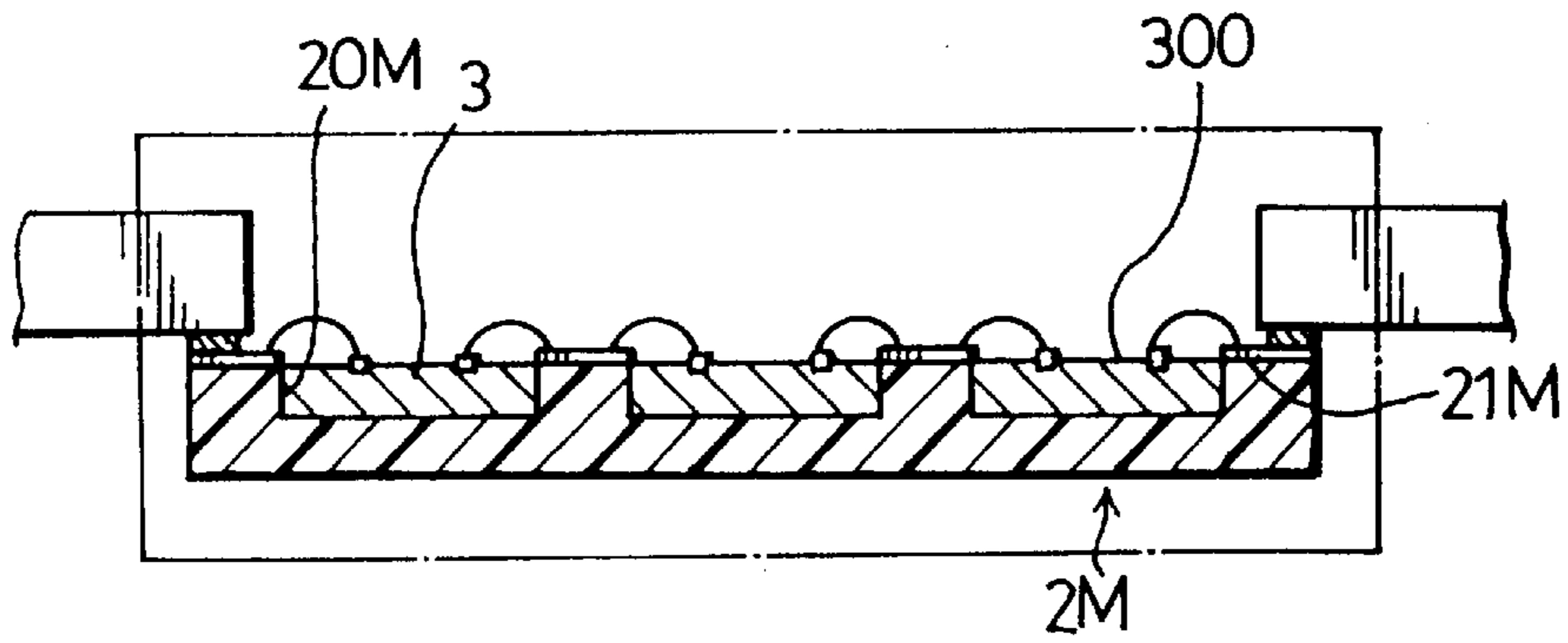


FIG. 15

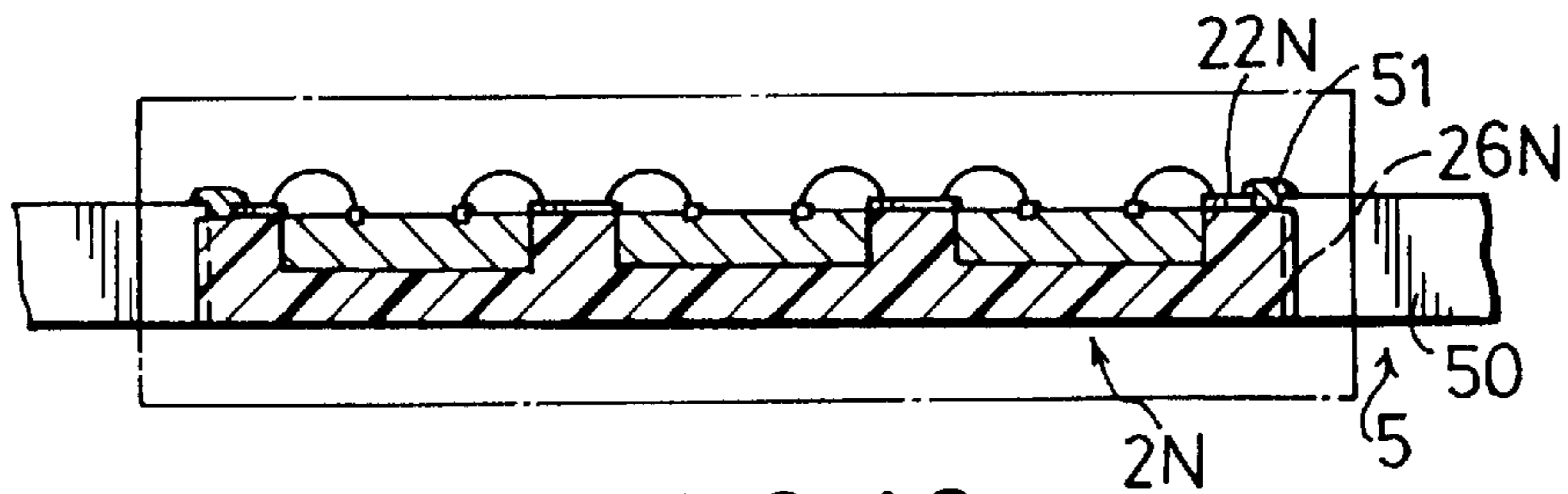


FIG. 16

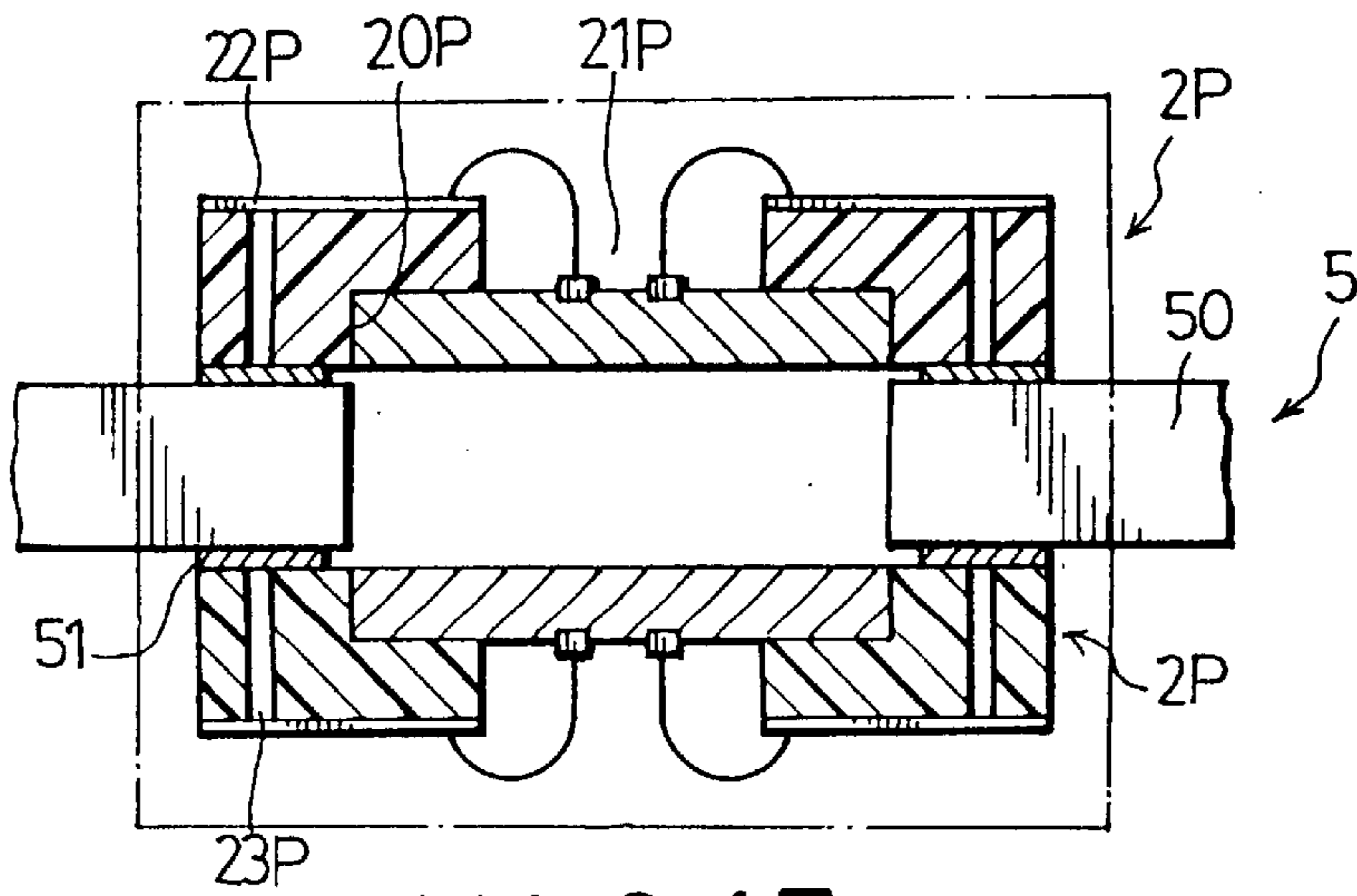


FIG. 17

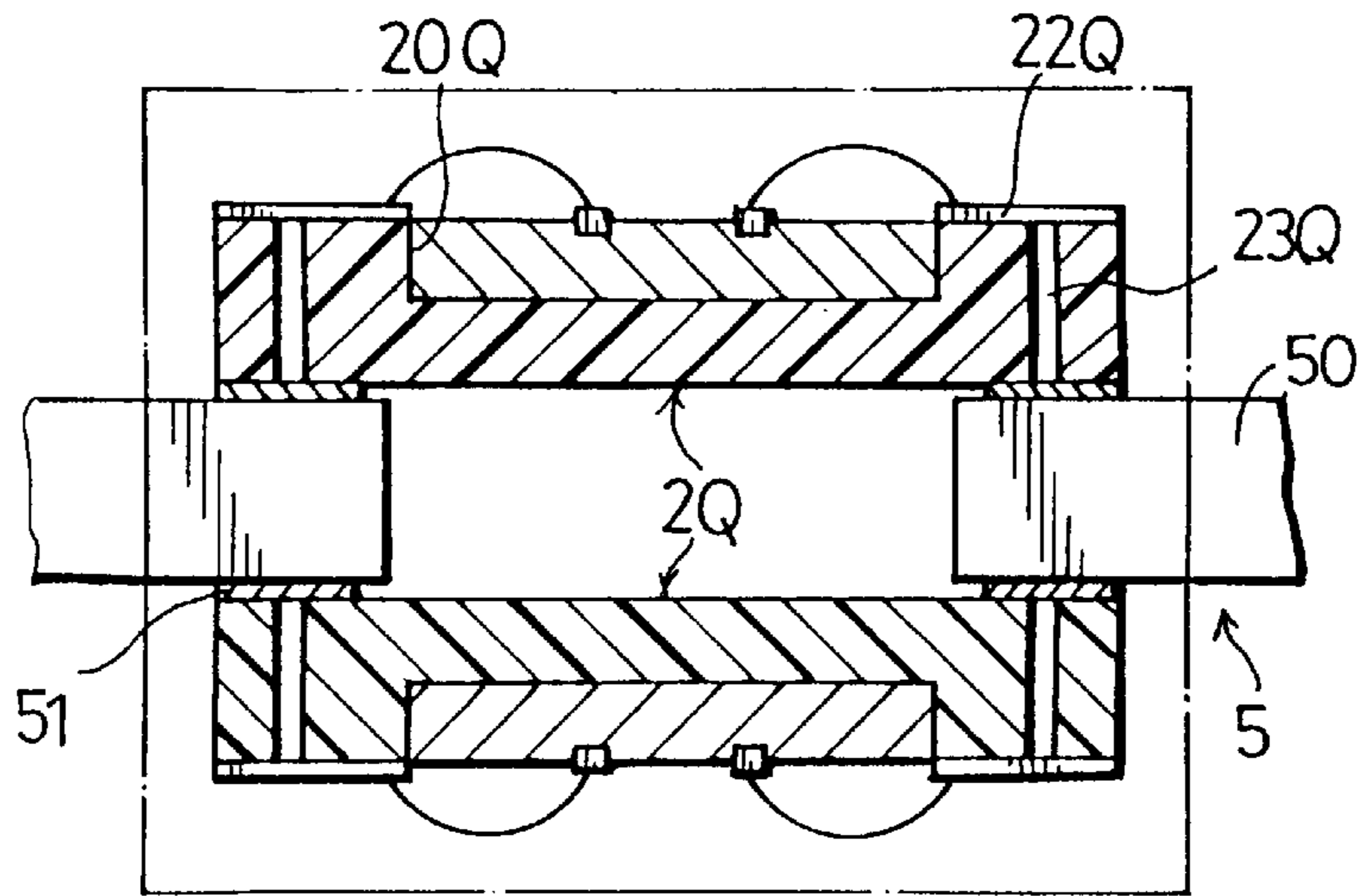


FIG. 18

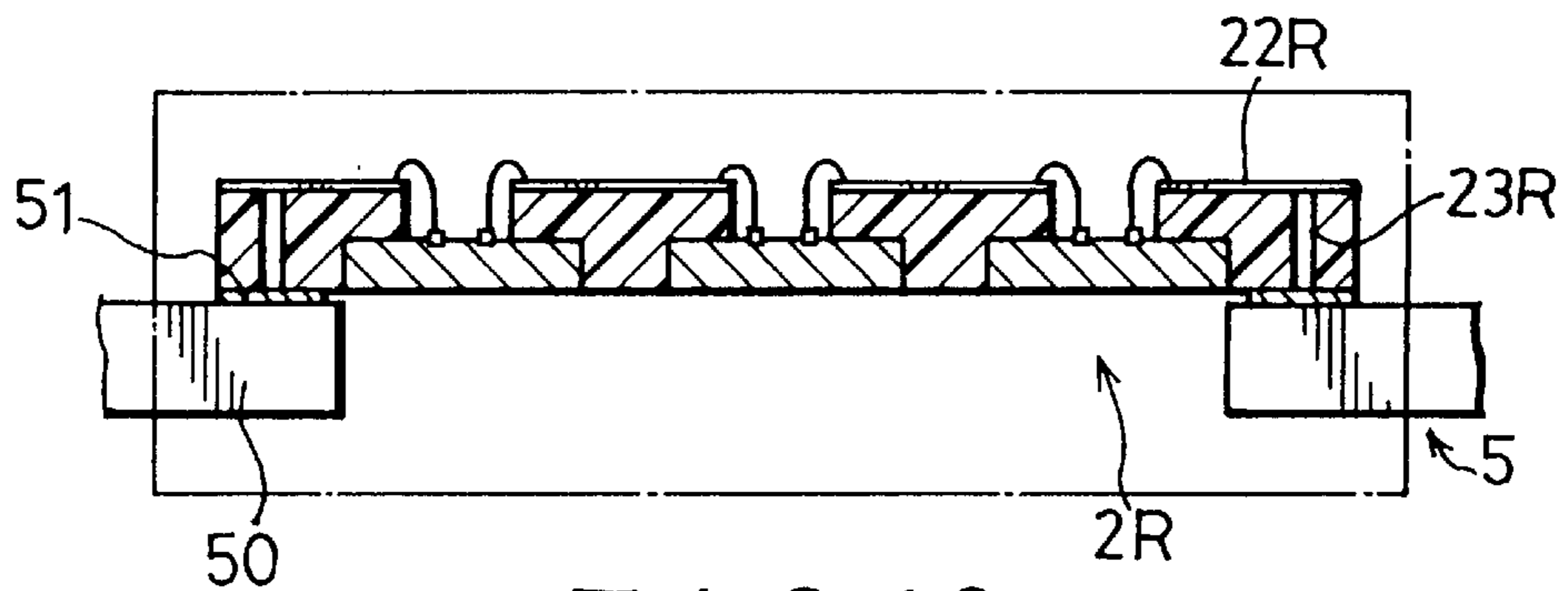


FIG. 19

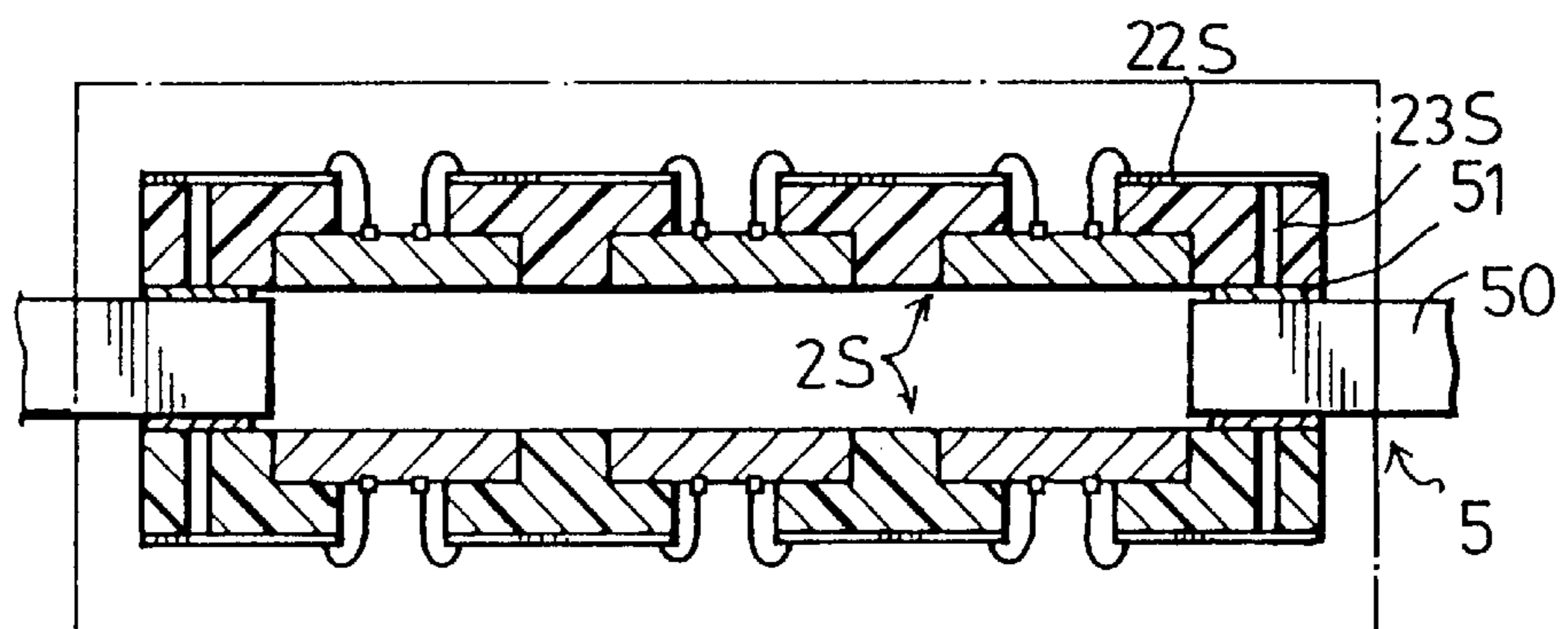


FIG. 20

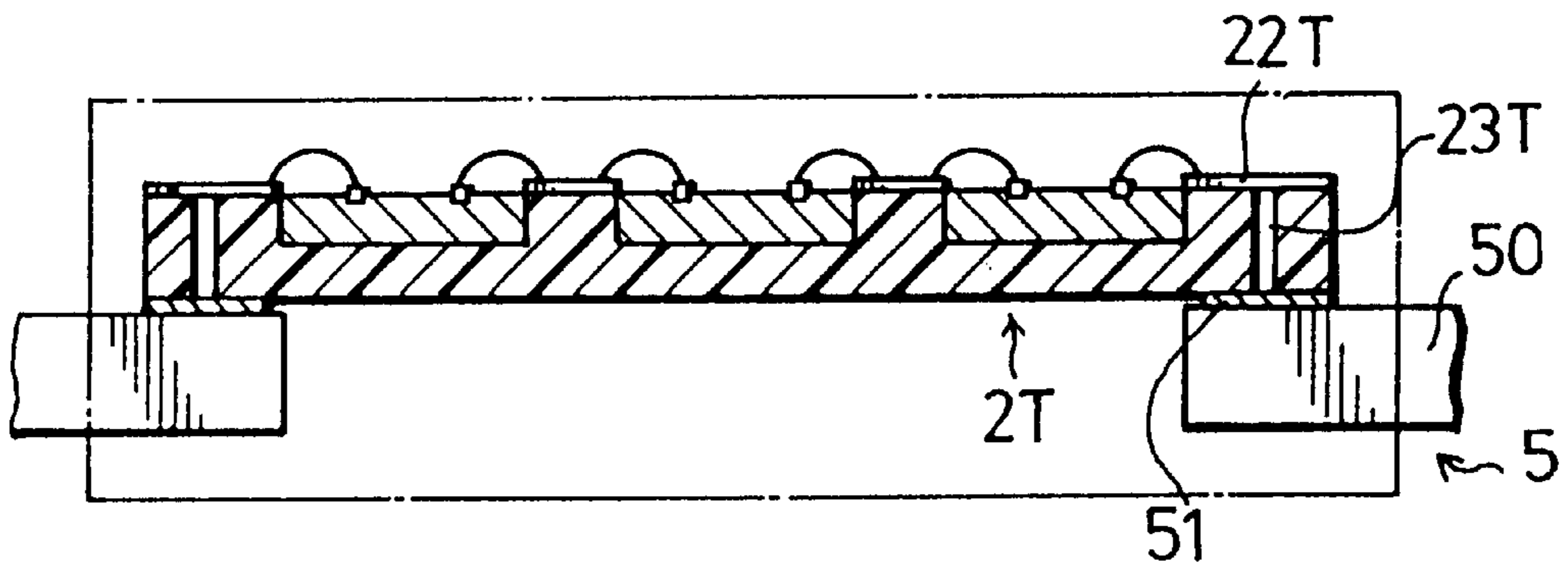


FIG. 21

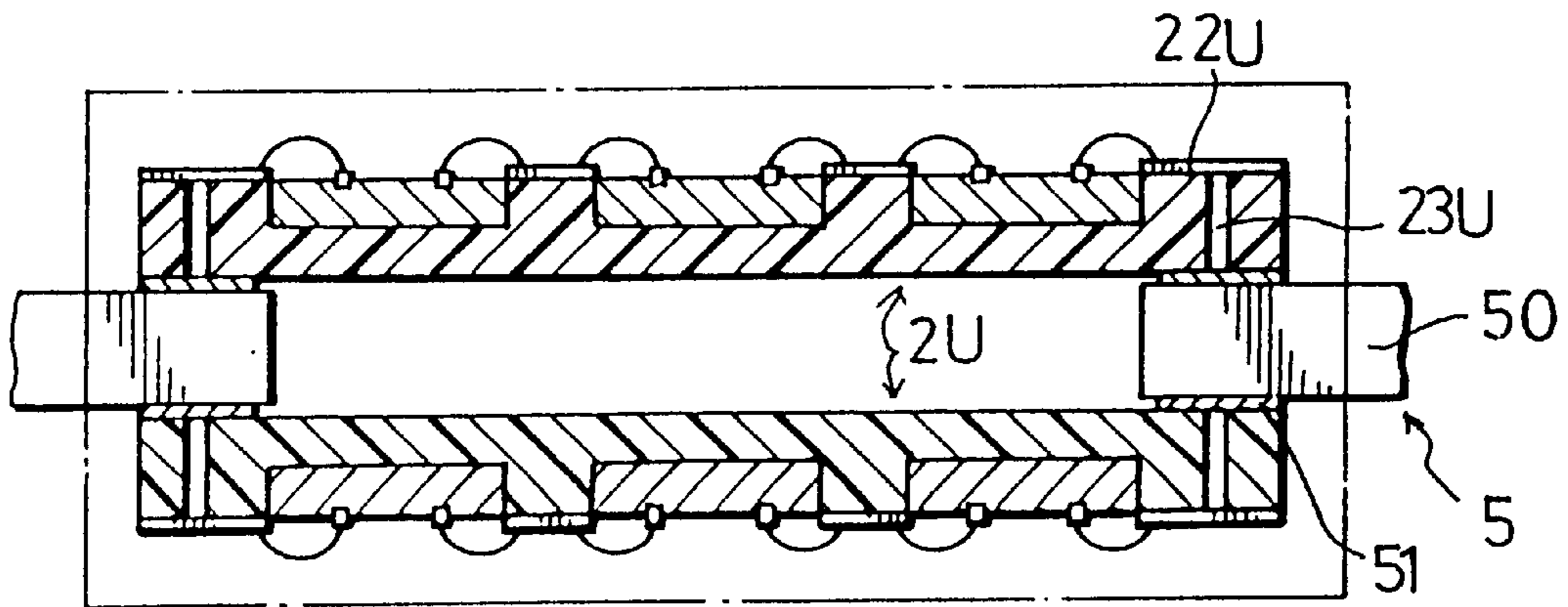


FIG. 22

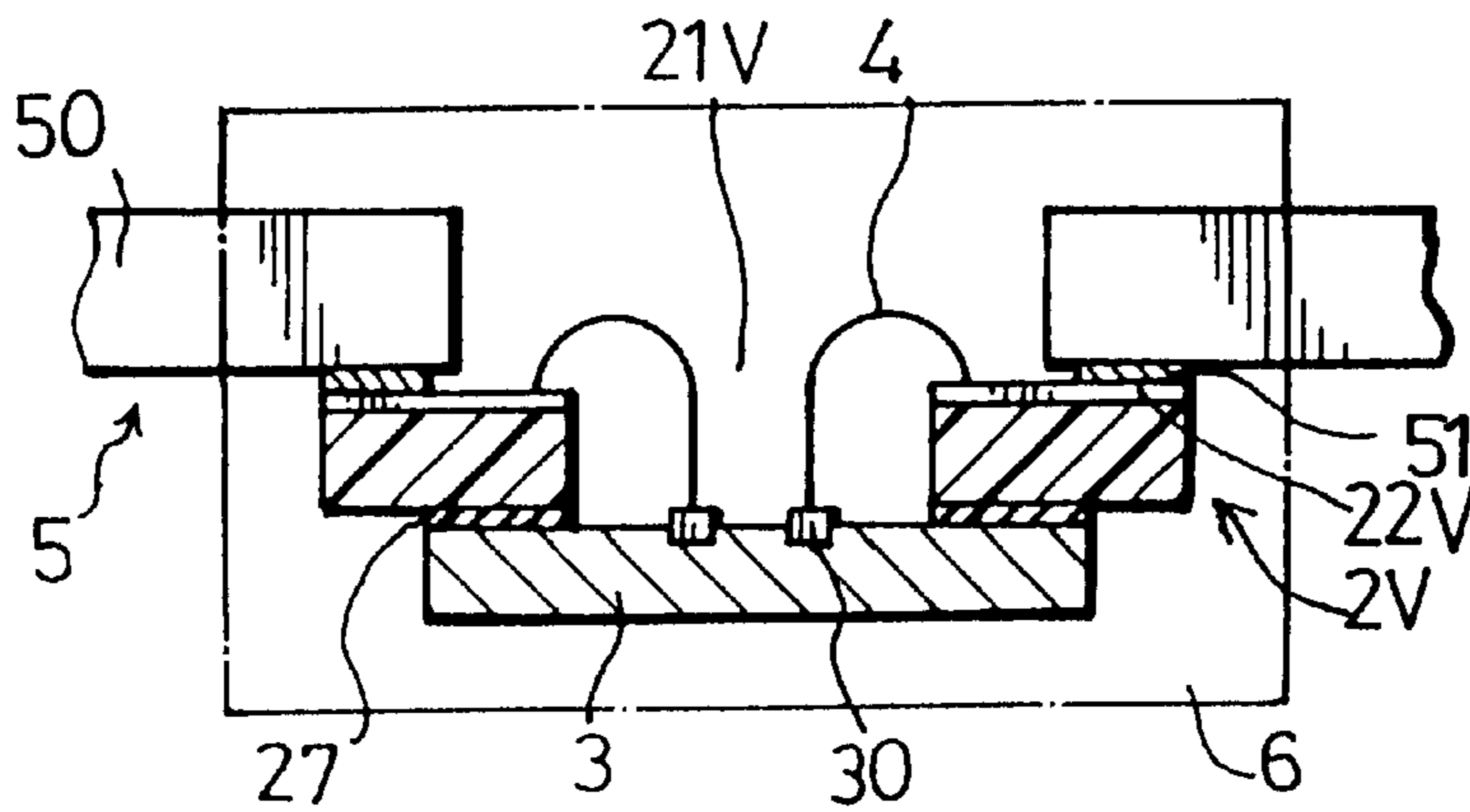


FIG. 23

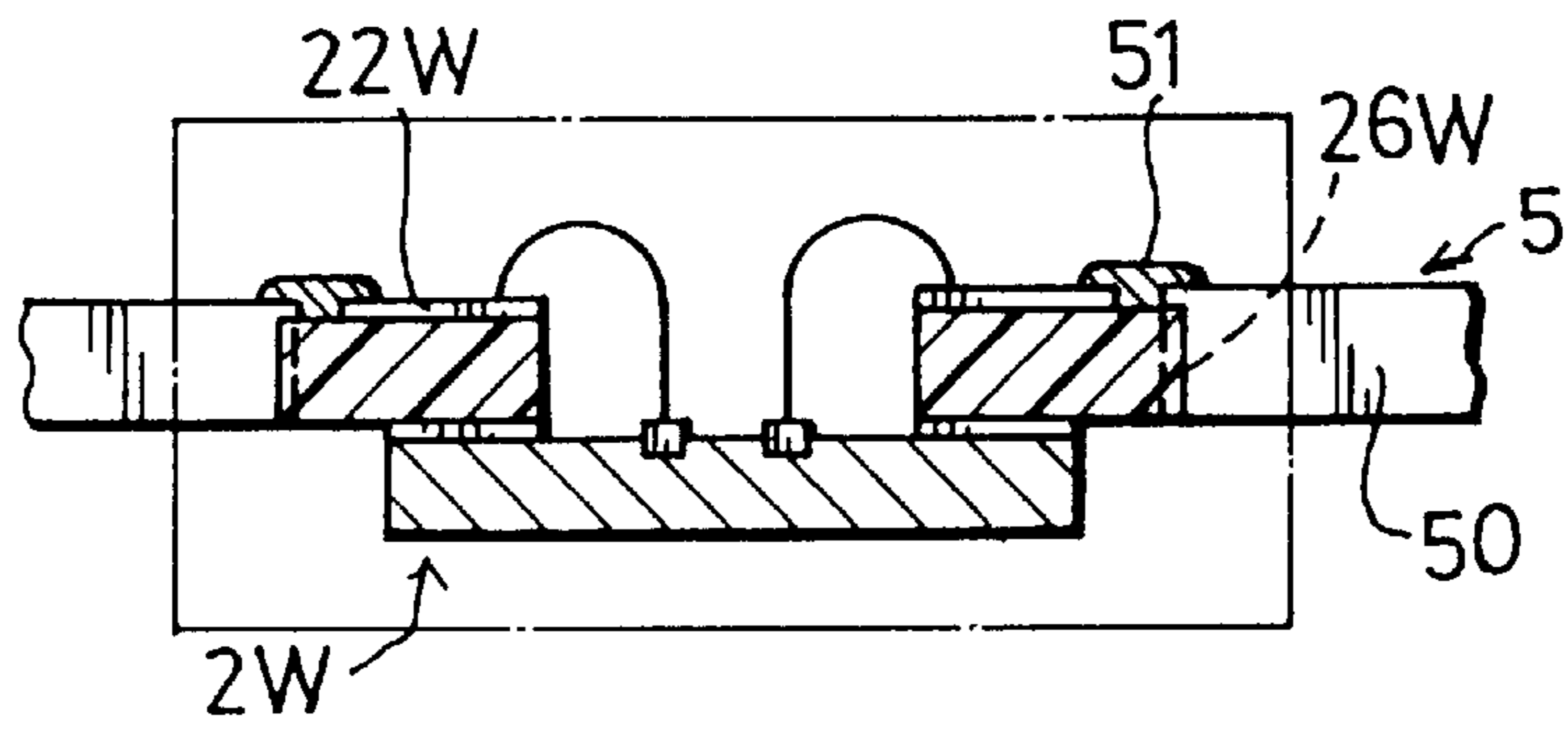


FIG. 24

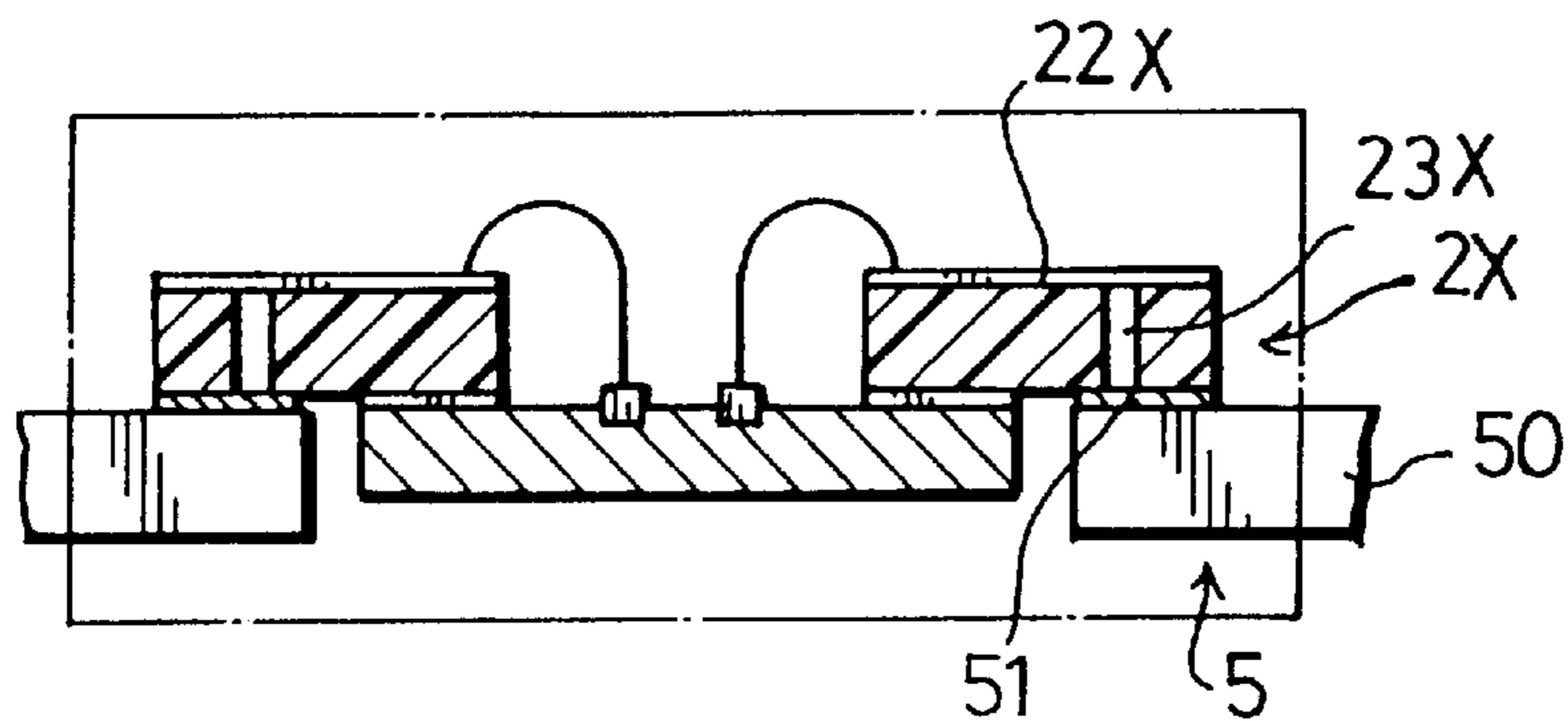


FIG. 25

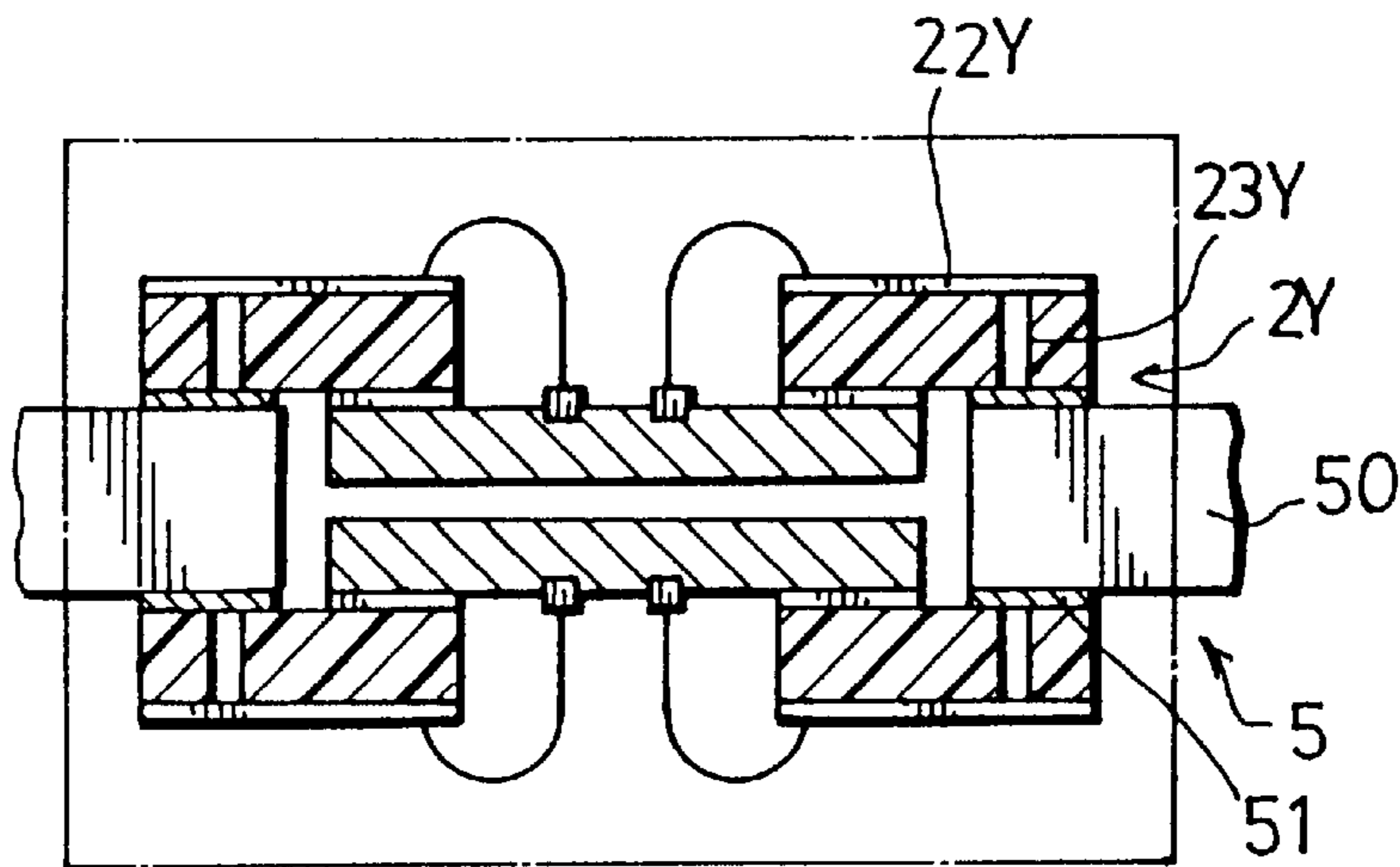


FIG. 26

INTEGRATED CIRCUIT CHIP AND METHOD FOR FABRICATING THE SAME

CROSS REFERENCE TO RELATED APPLICATIONS

This application is a Division of application Ser. No. 09/303,142 filed Apr. 30, 1999.

BACKGROUND OF THE INVENTION

1. Field of the Invention

The invention relates to an integrated circuit chip and a method for fabricating the same, more particularly to an integrated circuit chip and a method for fabricating the same that can reduce production costs and that can increase production capacity.

2. Description of the Related Art

Referring to FIGS. 1A to 1C, a conventional method for fabricating an integrated circuit chip is shown. As shown in FIG. 1A, a die **10** having an upper surface provided with a plurality of solder pads **100** is attached to a tie bar **130** on a lead frame **13** by means of a double-side adhesive tape **12** to fix the die **10** on the lead frame **13**. The solder pads **100** are exposed via a bore **1300** formed in the tie bar **130**, as shown in FIG. 1D. Referring to FIG. 1B, each of the solder pads **100** is connected electrically to a respective lead **131** of the lead frame **13** via known wire bonding-techniques by means of a conductive wire **14** that extends through the bore **1300**. Referring to FIG. 1C, a plastic protective layer **15** is used to encapsulate the die **10** and a portion of the lead frame **13** to form an integrated circuit chip.

The following are some of the drawbacks of the conventional method for fabricating an integrated circuit chip:

1. The aforesaid method needs different kinds of lead frames for different kinds of packaging, such as TSOP, SOJ, QFP, SOP and so on. Thus, at least one mold is prepared for each customer, thereby increasing costs.
2. In the aforesaid method, double-side adhesive tape is needed to secure the die on the tie bar, thereby increasing the fabricating costs.
3. In the aforesaid method, it will take a long time to form the molds for the lead frames, thereby affecting the ability of manufacturers to compete.

SUMMARY OF THE INVENTION

Therefore, the main object of the present invention is to provide an integrated circuit chip and a method for fabricating the same which can overcome the drawbacks associated with the aforesaid prior art.

According to this invention, a method for fabricating an integrated circuit chip comprises:

- (a) forming a circuit board unit with a die-receiving cavity, and a plurality of contact pads on a top surface of the circuit board unit;
- (b) forming a die having an upper surface provided with a plurality of solder pads;
- (c) placing the die in the die-receiving cavity such that the solder pads on the die are exposed;
- (d) wire-bonding the solder pads to the contact pads via conductive wires;
- (e) placing a lead frame on the circuit board unit, and connecting leads on the lead frame to corresponding ones of the contact pads via a conductive contact layer; and

- (f) forming a plastic protective layer to encapsulate the circuit board unit and at least a portion of the lead frame.

BRIEF DESCRIPTION OF THE DRAWINGS

Other features and advantages of the present invention will become apparent in the following detailed description of the preferred embodiments with reference to the accompanying drawings, of which:

FIGS. 1A to 1C are fragmentary schematic, partly sectional views showing a conventional method for fabricating an integrated circuit chip.

FIG. 1D is a fragmentary top view showing a lead frame used in the conventional method for fabricating an integrated circuit chip.

FIGS. 2A to 2D are fragmentary schematic, partly sectional views showing the first preferred embodiment of a method for fabricating an integrated circuit chip of this invention.

FIG. 2E is a fragmentary top view showing a lead frame used in the first preferred embodiment of this invention.

FIG. 3 is a fragmentary schematic, partly sectional view showing the second preferred embodiment of this invention.

FIG. 4 is a fragmentary schematic, partly sectional view showing the third preferred embodiment of this invention.

FIG. 5 is a fragmentary schematic, partly sectional view showing the fourth preferred embodiment of this invention.

FIG. 6 is a fragmentary schematic, partly sectional view showing the fifth preferred embodiment of this invention.

FIG. 7 is a fragmentary schematic, partly sectional view showing the sixth preferred embodiment of this invention.

FIG. 8 is a fragmentary schematic, partly sectional view showing the seventh preferred embodiment of this invention.

FIG. 9 is a fragmentary top view showing the seventh preferred embodiment of this invention.

FIG. 10 is a fragmentary schematic, partly sectional view showing the eighth preferred embodiment of this invention.

FIG. 11 is a fragmentary schematic, partly sectional view showing the ninth preferred embodiment of this invention.

FIG. 12 is a fragmentary schematic, partly sectional view showing the tenth preferred embodiment of this invention.

FIG. 13 is a fragmentary schematic, partly sectional view showing the eleventh preferred embodiment of this invention.

FIG. 14 is a fragmentary schematic, partly sectional view showing the twelfth preferred embodiment of this invention.

FIG. 15 is a fragmentary schematic, partly sectional view showing the thirteenth preferred embodiment of this invention.

FIG. 16 is a fragmentary schematic, partly sectional view showing the fourteenth preferred embodiment of this invention.

FIG. 17 is a fragmentary schematic, partly sectional view showing the fifteenth preferred embodiment of this invention.

FIG. 18 is a fragmentary schematic, partly sectional view showing the sixteenth preferred embodiment of this invention.

FIG. 19 is a fragmentary schematic, partly sectional view showing the seventeenth preferred embodiment of this invention.

FIG. 20 is a fragmentary schematic, partly sectional view showing the eighteenth preferred embodiment of this invention.

FIG. 21 is a fragmentary schematic, partly sectional view showing the nineteenth preferred embodiment of this invention.

FIG. 22 is a fragmentary schematic, partly sectional view showing the twentieth preferred embodiment of this invention.

FIG. 23 is a fragmentary schematic, partly sectional view showing the twenty-first preferred embodiment of this invention.

FIG. 24 is a fragmentary schematic, partly sectional view showing the twenty-second preferred embodiment of this invention.

FIG. 25 is a fragmentary schematic, partly sectional view showing the twenty-third preferred embodiment of this invention.

FIG. 26 is a fragmentary schematic, partly sectional view showing the twenty-fourth preferred embodiment of this invention.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

Before the present invention is described in greater detail, it should be noted that like elements are denoted by the same reference numerals throughout the disclosure.

Referring to FIGS. 2A to 2E, according to the first preferred embodiment of this invention, an integrated circuit chip includes a circuit board unit 2, a die 3, a plurality of conductive wires 4, a lead frame 5, a conductive contact layer 51, and a plastic protective layer 6. Referring to FIGS. 2A and 2B, the circuit board unit 2 has a bottom surface 200 formed with a die-receiving cavity 20, a top surface 210 formed with a bore 21 to access the die-receiving cavity 20, and a plurality of contact pads 22 on the top surface 210 of the circuit board unit 2. The die 3 has an upper surface 300 provided with a plurality of solder pads 30. The die 3 is placed inside the die-receiving cavity 20 such that the solder pads 30 are exposed via the bore 21 in the circuit board unit 2. Referring to FIG. 2C, the conductive wires 4 extend through the bore 21 and wire-bond the solder pads 30 to the contact pads 22. Referring to FIGS. 2C and 2D, the lead frame 5 is placed on top of the circuit board unit 2. The lead frame 5 has a plurality of leads 50. The conductive contact layer 51 is disposed between the lead frame 5 and the circuit board unit 2 to bond the leads 50 on the lead frame 5 onto corresponding ones of the contact pads 22. The conductive contact layer 51 is formed from a silver epoxy, such as one that contains both tin and lead, or solder paste that contains tin. The plastic protective layer 6 is used to encapsulate the circuit board unit 2 and at least a portion of the lead frame 5, as shown in FIG. 2E.

FIG. 3 illustrates the second preferred embodiment of this invention, which is based on the first preferred embodiment. In FIG. 3, unlike the first preferred embodiment shown in of FIG. 2D, the circuit board unit 2A is further formed with a plurality of electroplated holes 23 registered respectively with the contact pads 22A and extending through a bottom surface of the circuit board unit 2A. The lead frame 5 is placed below the circuit board unit 2A. The conductive contact layer 51 is disposed between the lead frame 5 and the circuit board unit 2A to bond leads 50 on the lead frame 5 onto the electroplated holes 23 to establish electrical connection with corresponding ones of the contact pads 22A.

FIG. 4 illustrates the third preferred embodiment of this invention, which is based on the first preferred embodiment. In FIG. 4, unlike the first preferred embodiment shown in

FIG. 2D, the circuit board unit 2B includes a lower circuit board 25 formed with the die-receiving cavity 20B, and an upper circuit board 24 superimposed on the lower circuit board 25 and formed with the bore 21B. The upper circuit board 24 has the contact pads 22B formed on the top surface thereof, and is further formed with first electroplated holes 240 registered respectively with the contact pads 22B. The lower circuit board 25 is formed with second electroplated holes 250 registered respectively with the first electroplated holes 240. Thus, circuit traces (not shown) on the bottom side of the lower circuit board 25 can be connected to the leads 50 of the lead frame 5 via the holes 250, 240 and the contact pads 22B.

FIG. 5 illustrates the fourth preferred embodiment of this invention, which is based on the first preferred embodiment. In FIG. 5, unlike the first preferred embodiment shown in FIG. 2D, the circuit board unit 2C has a top surface 21C formed with the die-receiving cavity 20C. The die 3 is placed in the die-receiving cavity 20C. The upper surface 300 of the die 3 is flush with the top surface 21C of the circuit board unit 2C.

FIG. 6 illustrates the fifth preferred embodiment of this invention, which is based on the fourth preferred embodiment. In FIG. 6, unlike the fourth preferred embodiment shown in FIG. 5, the circuit board unit 2D is further formed with a plurality of electroplated holes 23D registered respectively with the contact pads 22D and extending through a bottom surface of the circuit board unit 2D. The lead frame 5 is placed below the circuit board unit 2D. The conductive contact layer 51 is disposed between the lead frame 5 and the circuit board unit 2D to bond the leads 50 on the lead frame 5 onto the electroplated holes 23D to establish electrical connection with corresponding ones of the contact pads 22D.

FIG. 7 illustrates the sixth preferred embodiment of this invention, which is based on the fourth preferred embodiment. In FIG. 7, unlike the fourth preferred embodiment shown in FIG. 5, the circuit board unit 2E includes a lower circuit board 25E and an upper circuit board 24E superimposed on the lower circuit board 25E and formed with the die-receiving cavity 20E. The upper circuit board 24E has the contact pads 22E formed on a top surface 21E thereof, and is further formed with first electroplated holes 240E registered respectively with the contact pads 22E. The lower circuit board 25E is formed with second electroplated holes 250E registered respectively with the first electroplated holes 240E. Circuit traces (not shown) on the bottom side of the lower circuit board 25E can be connected to the contact pads 22E via the holes 250E, 240E.

FIGS. 8 and 9 illustrate the seventh preferred embodiment of this invention, which is based on the first preferred embodiment. In FIG. 8, unlike the first preferred embodiment shown in FIG. 2D, the circuit board unit 2F further has opposite side portions formed with a plurality of positioning notches 26 that correspond respectively to the contact pads 22F. Each of leads 50 on the lead frame 5 has one end inserted into a respective one of the positioning notches 26. The conductive contact layer 51 is used to bond the leads 50 on the lead frame 5 onto corresponding ones of the contact pads 22F. The height of the resulting integrated circuit chip can thus be reduced.

FIG. 10 illustrates the eighth preferred embodiment of this invention, which is based on the seventh preferred embodiment. In FIG. 10, unlike the seventh preferred embodiment shown in FIG. 8, the circuit board unit 2G includes a lower circuit board 25G formed with the die-

receiving cavity, and an upper circuit board **24G** superimposed on the lower circuit board **25G** and formed with the bore to access the die-receiving cavity. The upper circuit board **24G** has the contact pads **22G** on a top surface thereof, and is further formed with first electroplated holes **240G** registered respectively with the contact pads **22G**. The lower circuit board **25G** is formed with second electroplated holes **250G** registered respectively with the first electroplated holes **240G**. Circuit traces (not shown) on the bottom side of the lower circuit board **25G** can be connected to the contact pads **22G** via the holes **250G**, **240G**.

FIG. **11** illustrates the ninth preferred embodiment of this invention, which is based on the seventh preferred embodiment. In FIG. **11**, unlike the seventh preferred embodiment shown in FIG. **8**, the circuit board unit **2H** has a top surface **21H** formed with the die-receiving cavity **20H**. The die **3** is placed in the die-receiving cavity **20H**. An upper surface **360** of the die **3** is flush with the top surface **21H** of the circuit board unit **2H**.

FIG. **12** illustrates the tenth preferred embodiment of this invention, which is based on the ninth preferred embodiment. In FIG. **12**, unlike the ninth preferred embodiment shown in FIG. **11**, the circuit board unit **2I** includes a lower circuit board **25I** and an upper circuit board **24I** superimposed on the lower circuit board **25I** and formed with the die-receiving cavity **20I**. The upper circuit board **24I** has the contact pads **22I** formed on a top surface **21I** thereof, and is further formed with first electroplated holes **240I** registered respectively with the contact pads **22I**. The lower circuit board **25I** is formed with second electroplated holes **250I** registered respectively with the first electroplated holes **240I**. Circuit traces (not shown) on the bottom side of the lower circuit board **25I** can be connected to the contact pads **22I** via the holes **250I**, **240I**.

FIG. **13** illustrates the eleventh preferred embodiment of this invention. In this embodiment, a circuit board unit **2J** has a bottom surface formed with a plurality of die-receiving cavities **20J**, and a top surface formed with a plurality of bores **21J** to access a respective one of the die-receiving cavities **20J** and further formed with a plurality of contact pads **22J**. Each of a number of dies **3** has an upper surface provided with a plurality of, solder pads **30**. Each of the dies **3** is placed in a respective one of the die-receiving cavities **20J** such that the solder pads **30** on each of the dies **3** are exposed via a respective one of the bores **21J** in the circuit board unit **2J**. A plurality of conductive wires **4** extend through the bore **21J** and wire-bond the solder pads **30J** to the contact pads **22J**. A lead frame **5** is placed on top of the circuit board unit **2J**, and has a plurality of leads **50**. A conductive contact layer **51** is disposed between the lead frame **5** and the circuit board unit **2J** to bond the leads **50** on the lead frame **5** onto corresponding ones of the contact pads **22J**. Finally, a plastic protective layer **6** is used to encapsulate the circuit board unit **2J** and at least a portion of the lead frame **5**. Thus, surface mounting steps are reduced to enhance the production capacity.

FIG. **14** illustrates the twelfth preferred embodiment of this invention, which is based on the eleventh preferred embodiment. In FIG. **14**, unlike the eleventh preferred embodiment shown in FIG. **13**, the circuit board unit **2L** further has opposite side portions formed with a plurality of positioning notches **26L** that correspond respectively to the contact pads **22L**. Each of the leads **50** on the lead frame **5** has one end inserted into a respective one of the positioning notches **26L**. The conductive contact layer **51** is used to bond, the leads **50** on the lead frame **5** onto corresponding ones of the contact pads **22L**.

FIG. **15** illustrates the thirteenth preferred embodiment of this invention, which is based on the eleventh preferred embodiment shown in FIG. **13**, the circuit board unit **2M** has a top surface **21M** formed with a plurality of die-receiving cavities **20M**. Each of the dies **3** is placed in a respective one of the die-receiving cavities **20M**. An upper surface **300** of each die **3** is flush with the top surface **21M** of the circuit board unit **2M**.

FIG. **16** illustrates the fourteenth preferred embodiment of this invention, which is based on the thirteenth preferred embodiment shown in FIG. **15**, the circuit board unit **2N** further has opposite side portions formed with a plurality of positioning notches **26N** that correspond respectively to the contact pads **22N**. Each of the leads **50** on the lead frame **5** has one end inserted into a respective one of the positioning notches **26N**. A conductive contact layer **51** is used to bond the leads **50** on the lead frame **5** onto corresponding ones of the contact pads **22N**.

FIG. **17** is illustrates the fifteenth preferred embodiment of this invention, which is based on the second preferred embodiment shown in FIG. **3**, there are first and second circuit board units **2P** that are identical in construction. Each of the first and second circuit board units **2P** has a bottom surface formed with a die-receiving cavity **20P**, a top surface formed with a bore **21P** to access the die-receiving cavity **20P**, and a plurality of contact pads **22P** on the top surface. Each of the first and second circuit board units **2P** is further formed with a plurality of electroplated holes **23P** registered respectively with the contact pads **22P** and extending through the bottom surface thereof. The lead frame **5** is placed between the first and second circuit board units **2P**. Each of two conductive contact layers **51** is disposed between the lead frame **5** and a respective one of the first and second circuit board units **2P** to bond the leads **50** on the lead frame **5** onto respective ones of the electroplated holes **23P** to establish electrical connection with corresponding ones of the contact pads **22P**.

FIG. **18** is illustrates the sixteenth preferred embodiment of this invention, which is based on the fifth preferred embodiment shown in FIG. **6**, there are first and second circuit board units **2Q** that are identical in construction. Each of the first and second circuit board units **2Q** has a top surface formed with a die-receiving cavity **20Q** and a plurality of contact pads **22Q**, and a plurality of electroplated holes **23Q** that are registered respectively with the contact pads **22Q** and that extend through a bottom surface thereof. The lead frame **5** is placed between the first and second circuit board units **2P**. Each of two conductive contact layers **51** is disposed between the lead frame **5** and a respective one of the first and second circuit board units **2P** to bond the leads **50** on the lead frame **5** onto respective ones of the electroplated holes **23P** to establish electrical connection with corresponding ones of the contact pads **22P**.

FIG. **19** is illustrates the seventeenth preferred embodiment of this invention, which is based on the eleventh preferred embodiment shown in FIG. **13**, the circuit board unit **2R** is further formed with a plurality of electroplated holes **23R** registered respectively with the contact pads **22R** and extending through a bottom surface of the circuit board unit **2R**. The lead frame **5** is placed below the circuit board unit **2R**. The conductive contact layer **51** is disposed between the lead frame **5** and the circuit board unit **2R** to

bond the leads **50** on the lead frame **5** onto the electroplated holes **23R** to establish electrical connection with corresponding ones of the contact pads **22R**.

FIG. **20** illustrates the eighteenth preferred embodiment of this invention, which is based on the seventeenth preferred embodiment. In FIG. **20**, unlike the seventeenth preferred embodiment shown in FIG. **19**, there are first and second circuit board units **2S** that are identical in construction. Each of the first and second circuit board units **2S** is formed with a plurality of electroplated holes **23S** registered respectively with the contact pads **22S** and extending through a bottom surface thereof. The lead frame **5** is placed between the first and second circuit board units **2S**. Each of two conductive contact layers **51** is disposed between the lead frame **5** and a respective one of the first and second circuit board units **2S** to bond the leads **50** on the lead frame **5** onto respective ones of the electroplated holes **23S** to establish electrical connection with corresponding ones of the contact pads **22S**.

FIG. **21** illustrates the nineteenth preferred embodiment of this invention, which is based on the thirteenth preferred embodiment shown in FIG. **15**, the circuit board unit **2T** is further formed with a plurality of electroplated holes **23T** registered respectively with the contact pads **22T** and extending through a bottom surface of the circuit board unit **2T**. The lead frame **5** is placed below the circuit board unit **2T**. The conductive contact layer **51** is disposed between the lead frame **5** and the circuit board unit **2T** to bond the leads **50** on the lead frame **5** onto the electroplated holes **23T** to establish electrical connection with corresponding ones of the contact pads **22T**.

FIG. **22** illustrates the twentieth preferred embodiment of this invention, which is based on the nineteenth preferred embodiment shown in FIG. **19**, there are first and second circuit board units **2U** that are identical in construction. Each of the first and second circuit board units **2U** is formed with a plurality of electroplated holes **23U** registered respectively with the contact pads **22U** and extending through a bottom surface thereof. The lead frame **5** is placed between the first and second circuit board units **2U**. Each of two conductive contact layers **51** is disposed between the lead frame **5** and a respective one of the first and second circuit board units **2U** to bond the leads **50** on the lead frame **5** onto respective ones of the electroplated holes **23U** to establish electrical connection with corresponding ones of the contact pads **22U**.

FIG. **23** illustrates the twenty-first preferred embodiment of this invention. In this embodiment, a circuit board unit **2V** has a top surface formed with a bore **21V** and a plurality of contact pads **22V**. A die **3** has an upper surface provided with a plurality of solder pads **30**. The die **3** is attached to a bottom surface of the circuit board unit **2V** by an adhesive layer **27** such that the solder pads **30** on the die **3** are exposed via the bore **21V** in the circuit board unit **2V**. A plurality of conductive wires **4** extend through the bore **21V** and wire-bond the solder pads **30** to the contact pads **22V**. A lead frame **5** is placed on top of the circuit board unit **2V** and has a plurality of leads **50**. A conductive contact layer **51** bonds the leads **50** on the lead frame **5** onto corresponding ones of the contact pads **22V**. Finally, a plastic protective layer **6** is used to encapsulate the circuit board unit **2V** and at least a portion of the lead frame **5**.

FIG. **24** illustrates the twenty-second preferred embodiment of this invention, which is based on the twenty-first preferred embodiment. In FIG. **24**, unlike the twenty-first

preferred embodiment shown in FIG. **23**, the circuit board unit **2W** further has opposite side portions formed with a plurality of positioning notches **26W** that correspond respectively to the contact pads **22W**. Each of the leads **50** on the lead frame **5** has one end inserted into a respective one of the positioning notches **26W**. A conductive contact layer **51** is used to bond the leads **50** on the lead frame **5** onto corresponding ones of the contact pads **22W**.

FIG. **25** illustrates the twenty-third preferred embodiment of this invention, which is based on the twenty-first preferred embodiment shown in FIG. **23**, the circuit board unit **2X** is further formed with a plurality of electroplated holes **23X** registered respectively with the contact pads **22X** and extending through a bottom surface of the circuit board unit **2X**. The lead frame **5** is placed below the circuit board unit **2X**. The conductive contact layer **51** is disposed between the lead frame **5** and the circuit board unit **2X** to bond the leads **50** on the lead frame **5** onto the electroplated holes **23X** to establish electrical connection with corresponding ones of the contact pads **22X**.

FIG. **26** illustrates the twenty-fourth preferred embodiment of this invention, which is based on the twenty-third preferred embodiment. In FIG. **26**, unlike the twenty-third preferred embodiment shown in FIG. **25**, there are first and second circuit board units **2Y** that are identical in construction. Each of the first and second circuit board units **2Y** is formed with a plurality of electroplated holes **23Y** registered respectively with the contact pads **22Y** and extending through a bottom surface thereof. The lead frame **5** is placed between the first and second circuit board units **2Y**. Each of two conductive contact layers **51** is disposed between the lead frame **5** and a respective one of the first and second circuit board units **2Y** to bond the leads **50** on the lead frame **5** onto respective ones of the electroplated holes **23Y** to establish electrical connection with corresponding ones of the contact pads **22Y**.

While the present invention has been described in connection with what is considered the most practical and preferred embodiments, it is understood that this invention is not limited to the disclosed embodiments but is intended to cover various arrangements included within the spirit and scope of the broadest interpretation so as to encompass all such modifications and equivalent arrangements.

I claim:

1. An integrated circuit chip comprising:

a circuit board unit having a top surface formed with at least two die-receiving cavities and a plurality of contact pads;

at least two dies, each having an upper surface provided with a plurality of solder pads, each of said dies being placed in a respective one of said die-receiving cavities such that said solder pads on each of said dies are exposed from the respective one of said die receiving cavities;

a plurality of conductive wires that wire-bond said solder pads to said contact pads;

a lead frame placed on top of said circuit board unit, said lead frame having a plurality of leads;

a conductive contact layer that bonds said leads on said lead frame onto corresponding ones of said contact pads; and a

plastic protective layer to encapsulate said circuit board unit and at least a portion of said lead frame.

2. The integrated circuit chip of claim 1, wherein said conductive contact layer is formed from a silver epoxy.

3. The integrated circuit chip of claim 1, wherein said conductive contact layer is formed from solder paste.
4. An integrated circuit chip comprising:
- a circuit board unit having a bottom surface formed with at least two die-receiving cavities, a top surface formed with at least two bores to access a respective one of said die-receiving cavities and further formed with a plurality of contact pads, and opposite side portions formed with a plurality of positioning notches that correspond respectively to said contact pads;
 - at least two dies, each having an upper surface provided with a plurality of solder pads, each of said dies being placed in a respective one of said die-receiving cavities such that said solder pads on each of said dies are exposed via a respective one of said bores in said circuit board unit;
 - a plurality of conductive wires that extend through said bores and that wire-bond said solder pads to said contact pads;
 - a lead frame having a plurality of leads, one end of each of said leads being inserted into a respective one of said positioning notches;
 - a conductive contact layer to bond said leads on said lead frame onto corresponding ones of said contact pads adjacent to said side portions of said circuit board unit; and
 - a plastic protective layer to encapsulate said circuit board unit and at least a portion of said lead frame.
5. The integrated circuit chip of claim 4, wherein said conductive contact layer is formed from a silver epoxy.

6. The integrated circuit chip of claim 4, wherein said conductive contact layer is formed from solder paste.
7. An integrated circuit chip comprising:
- a circuit board unit having a top surface formed with at least two die-receiving cavities and a plurality of contact pads, and opposite side portions formed with a plurality of positioning notches that correspond respectively to said contact pads;
 - at least two dies, each having an upper surface provided with a plurality of solder pads, each of said dies being placed in a respective one of said die-receiving cavities such that said solder pads on each of said dies are exposed from the respective one of said die-receiving cavities;
 - a plurality of conductive wires that wire-bond said solder pads to said contact pads;
 - a lead frame having a plurality of leads, one end of each of said leads being inserted into a respective one of said positioning notches;
 - a conductive contact layer to bond said leads on said lead frame onto corresponding ones of said contact pads adjacent to said opposite side portions of said circuit board unit; and
 - a plastic protective layer to encapsulate said circuit board unit and at least a portion of said lead frame.
8. The integrated circuit chip of claim 7, wherein said conductive contact layer is formed from a silver epoxy.
9. The integrated circuit chip of claim 7, wherein said conductive contact layer is formed from solder paste.

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